DLP3010LC 0.3 720p DMD

1 Features

- 0.3-Inch (7.93-mm) diagonal micromirror array
  - 1280 × 720 array of aluminum micrometer-sized mirrors, in an orthogonal layout
  - 5.4 – micron micromirror pitch
  - ±17° micromirror tilt (relative to flat surface)
  - Side illumination for optimal efficiency and optical engine size
  - Polarization independent aluminum micromirror surface
- 8-Bit SubLVDS input data bus
- Dedicated DLPC3478 display and light controller and DLPA200x or DLPA300x PMIC/LED driver for reliable operation

2 Applications

- Integrated display and 3D depth capture
  - Smart phone, tablets, laptop, camera
  - Battery-powered mobile accessory
- 3D depth capture: 3D camera, 3D reconstruction, AR/VR, dental scanner
- 3D machine vision: robotics, metrology, in-line inspection (AOI)
- 3D biometrics: facial and finger print recognition
- Light exposure: 3D printers, programmable spatial and temporal light exposure

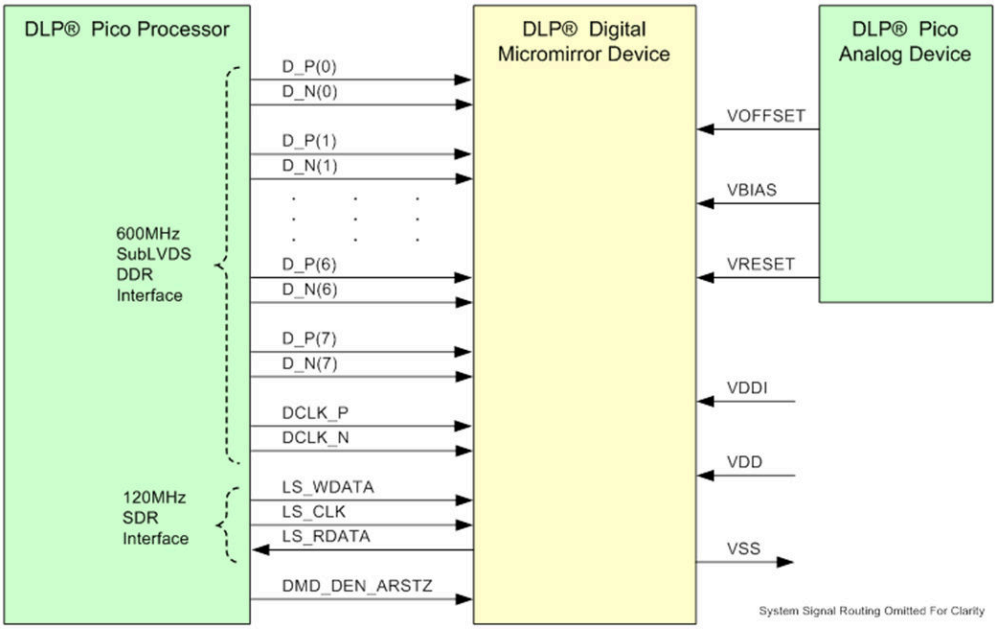
3 Description

The 7212-313BK digital micromirror device (DMD) is a digitally controlled micro-opto-electromechanical system (MOEMS) spatial light modulator (SLM). When coupled to an appropriate optical system, the DMD displays a very crisp and high quality image or video. This DMD is a component of the chipset comprising the DMD, DLPC3478 display and light controller, and DLPA200x/DLPA300x PMIC/LED driver. The compact physical size of this DMD coupled with the controller and the PMIC/LED driver provides a complete system solution that enables small form factor, low power, and high-resolution, light-control applications like such as 3D scanners.

Device Information(1)

PART NUMBER	PACKAGE	BODY SIZE (NOM)
7212-313BK	FQK (57)	18.20-mm × 7.00-mm

(1) For all available packages, see the orderable addendum at the end of the data sheet.



7212-313BK 0.3 720p Chipset

An IMPORTANT NOTICE at the end of this data sheet addresses availability, warranty, changes, use in safety-critical applications, intellectual property matters and other important disclaimers. PRODUCTION DATA.

Table of Contents

4 Revision History

NOTE: Page numbers for previous revisions may differ from page numbers in the current version.

Changes from Revision A (November 2021) to Revision B (May 2022)	Page
• Updated Absolute Maximum Ratings disclosure to the latest TI standard	6
• Updated *Micromirror Array Optical Characteristics*	18
• Added *Third-Party Products Disclaimer*	36

Changes from Revision * (April 2020) to Revision A (November 2021)	Page
• Updated the numbering format for tables, figures, and cross-references throughout the document	1
• Updated $\|T_{DELTA}\|$ MAX from 30°C to 15°C	7

Copyright © 2022 Texas Instruments Incorporated

5 Pin Configuration and Functions

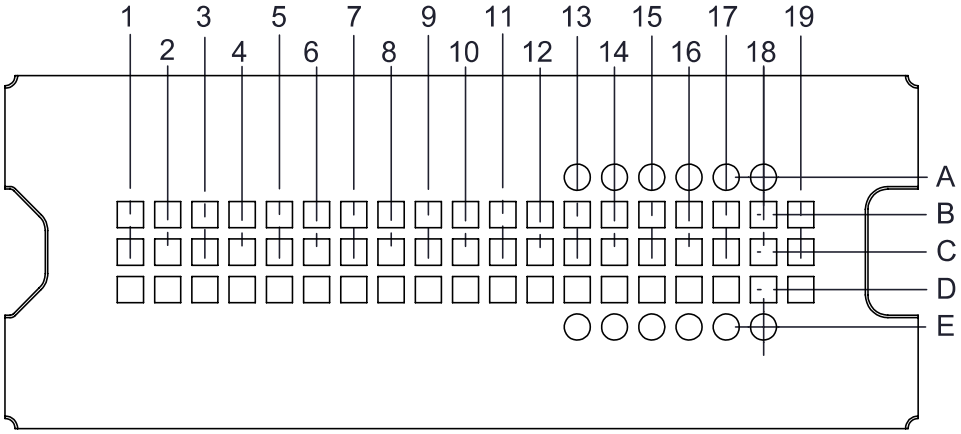


Figure 5-1. FQK Package 57-Pin LGA (Bottom View)

Table 5-1. Pin Functions – Connector Pins(1)

PIN		TYPE	SIGNAL	DATA RATE	DESCRIPTION	PACKAGE NET LENGTH(2) (mm)
NAME	NO.					
DATA INPUTS						
D_N(0)	C9	I	SubLVDS	Double	Data, Negative	10.54
D_P(0)	B9	I	SubLVDS	Double	Data, Positive	10.54
D_N(1)	D10	I	SubLVDS	Double	Data, Negative	13.14
D_P(1)	D11	I	SubLVDS	Double	Data, Positive	13.14
D_N(2)	C11	I	SubLVDS	Double	Data, Negative	14.24
D_P(2)	B11	I	SubLVDS	Double	Data, Positive	14.24
D_N(3)	D12	I	SubLVDS	Double	Data, Negative	14.35
D_P(3)	D13	I	SubLVDS	Double	Data, Positive	14.35
D_N(4)	D4	I	SubLVDS	Double	Data, Negative	5.89
D_P(4)	D5	I	SubLVDS	Double	Data, Positive	5.89
D_N(5)	C5	I	SubLVDS	Double	Data, Negative	5.45
D_P(5)	B5	I	SubLVDS	Double	Data, Positive	5.45
D_N(6)	D6	I	SubLVDS	Double	Data, Negative	8.59
D_P(6)	D7	I	SubLVDS	Double	Data, Positive	8.59
D_N(7)	C7	I	SubLVDS	Double	Data, Negative	7.69
D_P(7)	B7	I	SubLVDS	Double	Data, Positive	7.69
DCLK_N	D8	I	SubLVDS	Double	Clock, Negative	8.10
DCLK_P	D9	I	SubLVDS	Double	Clock, Positive	8.10
CONTROL INPUTS						
LS_WDATA	C12	I	LPSDR(1)	Single	Write data for low speed interface.	7.16
LS_CLK	C13	I	LPSDR	Single	Clock for low-speed interface	7.89
DMD_DEN_ARSTZ	C14	I	LPSDR		Asynchronous reset DMD signal. A low signal places the DMD in reset. A high signal releases the DMD from reset and places it in active mode.	
LS_RDATA	C15	O	LPSDR	Single	Read data for low-speed interface	
POWER (3)						
VBIAS	C1	Power			Supply voltage for positive bias level at micromirrors	
VBIAS	C18	Power				

Copyright © 2022 Texas Instruments Incorporated

Table 5-1. Pin Functions – Connector Pins(1) (continued)

PIN		TYPE	SIGNAL	DATA RATE	DESCRIPTION	PACKAGE NET LENGTH(2) (mm)
NAME	NO.					
VOFFSET	D1	Power			Supply voltage for HVCMOS core logic. Supply voltage for stepped high level at micromirror address electrodes. Supply voltage for offset level at micromirrors.	
VOFFSET	D17	Power				
VRESET	B1	Power			Supply voltage for negative reset level at micromirrors.	
VRESET	B18	Power				
VDD	B6	Power			Supply voltage for LVCMOS core logic. Supply voltage for LPSDR inputs. Supply voltage for normal high level at micromirror address electrodes.	
VDD	B10	Power				
VDD	B19	Power				
VDD	C6	Power				
VDD	C10	Power				
VDD	C19	Power				
VDD	D2	Power				
VDD	D18	Power				
VDD	D19	Power				
VDDI	B2	Power			Supply voltage for SubLVDS receivers.	
VDDI	C2	Power				
VDDI	C3	Power				
VDDI	D3	Power				
VSS	B3	Ground			Common return. Ground for all power.	
VSS	B4	Ground				
VSS	B8	Ground				
VSS	B12	Ground				
VSS	B13	Ground				
VSS	B14	Ground				
VSS	B15	Ground				
VSS	B16	Ground				
VSS	B17	Ground				
VSS	C4	Ground				
VSS	C8	Ground				
VSS	C16	Ground				
VSS	C17	Ground				
VSS	D14	Ground				
VSS	D15	Ground				
VSS	D16	Ground				

(1) Low speed interface is LPSDR and adheres to the Electrical Characteristics and AC/DC Operating Conditions table in JEDEC Standard No. 209B, *Low Power Double Data Rate (LPDDR)* JESD209B.
(2) Net trace lengths inside the package:
Relative dielectric constant for the FQK ceramic package is 9.8.
Propagation speed = 11.8 / sqrt (9.8) = 3.769 inches/ns.
Propagation delay = 0.265 ns/inch = 265 ps/inch = 10.43 ps/mm.
(3) The following power supplies are all required to operate the DMD: VSS, VDD, VDDI, VOFFSET, VBIAS, VRESET.

Copyright © 2022 Texas Instruments Incorporated

Table 5-2. Pin Functions – Test Pads

NUMBER	SYSTEM BOARD
A13	Do not connect
A14	Do not connect
A15	Do not connect
A16	Do not connect
A17	Do not connect
A18	Do not connect
E13	Do not connect
E14	Do not connect
E15	Do not connect
E16	Do not connect
E17	Do not connect
E18	Do not connect

Copyright © 2022 Texas Instruments Incorporated

6 Specifications

6.1 Absolute Maximum Ratings

See (1)

			MIN	MAX	UNIT
Supply voltage	VDD	Supply voltage for LVCMOS core logic(2) Supply voltage for LPSDR low speed interface	–0.5	2.3	V
	VDDI	Supply voltage for SubLVDS receivers(2)	–0.5	2.3	V
	VOFFSET	Supply voltage for HVCMOS and micromirror electrode(2) (3)	–0.5	11	V
	VBIAS	Supply voltage for micromirror electrode(2)	–0.5	19	V
	VRESET	Supply voltage for micromirror electrode(2)	–15	0.5	V
	| VDDI–VDD |	Supply voltage delta (absolute value)(4)		0.3	V
	| VBIAS–VOFFSET |	Supply voltage delta (absolute value)(5)		11	V
	| VBIAS–VRESET |	Supply voltage delta (absolute value)(6)		34	V
Input voltage	Input voltage for other inputs LPSDR(2)		–0.5	VDD + 0.5	V
	Input voltage for other inputs SubLVDS(2) (7)		–0.5	VDDI + 0.5	V
Input pins	| VID |	SubLVDS input differential voltage (absolute value)(7)		810	mV
	IID	SubLVDS input differential current		10	mA
Clock frequency	f_{clock}	Clock frequency for low speed interface LS_CLK		130	MHz
	f_{clock}	Clock frequency for high speed interface DCLK		560	MHz
Environmental	T_{ARRAY} and T_{WINDOW}	Temperature – operational (8)	–20	90	°C
		Temperature – non-operational(8)	–40	90	°C
	T_{DP}	Dew Point Temperature - operating and non-operating (non-condensing)		81	°C
	$\|T_{DELTA}\|$	Absolute Temperature delta between any point on the window edge and the ceramic test point TP1(9)		30	°C

(1) Operation outside the Absolute Maximum Ratings may cause permanent device damage. Absolute Maximum Ratings do not imply functional operation of the device at these or any other conditions beyond those listed under Recommended Operating Conditions. If outside the Recommended Operating Conditions but within the Absolute Maximum Ratings, the device may not be fully functional, and this may affect device reliability, functionality, performance, and shorten the device lifetime.
(2) All voltage values are with respect to the ground terminals (VSS). The following power supplies are all required to operate the DMD: VSS, VDD, VDDI, VOFFSET, VBIAS, and VRESET.
(3) VOFFSET supply transients must fall within specified voltages.
(4) Exceeding the recommended allowable absolute voltage difference between VDDI and VDD may result in excessive current draw.
(5) Exceeding the recommended allowable absolute voltage difference between VBIAS and VOFFSET may result in excessive current draw.
(6) Exceeding the recommended allowable absolute voltage difference between VBIAS and VRESET may result in excessive current draw.
(7) This maximum input voltage rating applies when each input of a differential pair is at the same voltage potential. Sub-LVDS differential inputs must not exceed the specified limit or damage may result to the internal termination resistors.
(8) The highest temperature of the active array (as calculated by the *Section 7.6*) or of any point along the Window Edge as defined in Figure 7-1. The locations of thermal test points TP2 and TP3 in Figure 7-1 are intended to measure the highest window edge temperature. If a particular application causes another point on the window edge to be at a higher temperature, that point should be used.
(9) Temperature delta is the highest difference between the ceramic test point 1 (TP1) and anywhere on the window edge as shown in Figure 7-1. The window test points TP2 and TP3 shown in Figure 7-1 are intended to result in the worst case delta. If a particular application causes another point on the window edge to result in a larger delta temperature, that point should be used.

Copyright © 2022 Texas Instruments Incorporated

6.2 Storage Conditions

applicable for the DMD as a component or non-operational in a system

		MIN	MAX	UNIT
T_{DMD}	DMD storage temperature	–40	85	°C
T_{DP-AVG}	Average dew point temperature, (non-condensing)(1)		24	°C
T_{DP-ELR}	Elevated dew point temperature range, (non-condensing)(2)	28	36	°C
CT_{ELR}	Cumulative time in elevated dew point temperature range		6	Months

(1) The average over time (including storage and operating) that the device is not in the elevated dew point temperature range.
(2) Exposure to dew point temperatures in the elevated range during storage and operation should be limited to less than a total cumulative time of CT_{ELR}.

6.3 ESD Ratings

			VALUE	UNIT
$V_{(ESD)}$	Electrostatic discharge	Human body model (HBM), per ANSI/ESDA/JEDEC JS-001(1)	±2000	V

(1) JEDEC document JEP155 states that 500 V HBM allows safe manufacturing with a standard ESD control process.

6.4 Recommended Operating Conditions

over operating free-air temperature range (unless otherwise noted)(1) (2) (3)

		MIN	NOM	MAX	UNIT
SUPPLY VOLTAGE RANGE(4)					
VDD	Supply voltage for LVCMOS core logic Supply voltage for LPSDR low-speed interface	1.65	1.8	1.95	V
VDDI	Supply voltage for SubLVDS receivers	1.65	1.8	1.95	V
VOFFSET	Supply voltage for HVCMOS and micromirror electrode(5)	9.5	10	10.5	V
VBIAS	Supply voltage for mirror electrode	17.5	18	18.5	V
VRESET	Supply voltage for micromirror electrode	–14.5	–14	–13.5	V
|VDDI–VDD|	Supply voltage delta (absolute value)(6)			0.3	V
|VBIAS–VOFFSET|	Supply voltage delta (absolute value)(7)			10.5	V
|VBIAS–VRESET|	Supply voltage delta (absolute value)(8)			33	V
CLOCK FREQUENCY					
f_{clock}	Clock frequency for low speed interface LS_CLK(9)	108		120	MHz
f_{clock}	Clock frequency for high speed interface DCLK(10)	300		600	MHz
	Duty cycle distortion DCLK	44%		56%	
SUBLVDS INTERFACE(10)					
$\lvert V_{ID} \rvert$	SubLVDS input differential voltage (absolute value) Figure 6-9, Figure 6-10	150	250	350	mV
V_{CM}	Common mode voltage Figure 6-9, Figure 6-10	700	900	1100	mV
$V_{SUBLVDS}$	SubLVDS voltage Figure 6-9, Figure 6-10	575		1225	mV
Z_{LINE}	Line differential impedance (PWB/trace)	90	100	110	Ω
Z_{IN}	Internal differential termination resistance Figure 6-11	80	100	120	Ω
	100-Ω differential PCB trace	6.35		152.4	mm

Copyright © 2022 Texas Instruments Incorporated

6.4 Recommended Operating Conditions (continued)

over operating free-air temperature range (unless otherwise noted)(1) (2) (3)

		MIN	NOM	MAX	UNIT
ENVIRONMENTAL					
T_{ARRAY}	Array Temperature – long-term operational(11) (12) (13) (14)	0		40 to 70(13)	°C
	Array Temperature - short-term operational, 25 hr max(12) (15)	–20		–10	
	Array Temperature - short-term operational, 500 hr max(12) (15)	–10		0	
	Array Temperature – short-term operational, 500 hr max(12) (15)	70		75	
$\lvert T_{DELTA} \rvert$	Absolute Temperature difference between any point on the window edge and the ceramic test point TP1 (16)			15	°C
T_{WINDOW}	Window temperature – operational(11) (17)			90	°C
T_{DP-AVG}	Average dew point temperature (non-condensing)(18)			24	°C
T_{DP-ELR}	Elevated dew point temperature range (non-condensing)(19)	28		36	°C
CT_{ELR}	Cumulative time in elevated dew point temperature range			6	Months
ILL_{UV}	Illumination wavelengths < 420 nm(11)			0.68	mW/cm^2
ILL_{VIS}	Illumination wavelengths between 420 nm and 700 nm			Thermally limited	
ILL_{IR}	Illumination wavelengths > 700 nm			10	mW/cm^2
ILL_{θ}	Illumination marginal ray angle(20)			55	deg

(1) *Section 6.4* are applicable after the DMD is installed in the final product.
(2) The functional performance of the device specified in this datasheet is achieved when operating the device within the limits defined by the *Section 6.4*. No level of performance is implied when operating the device above or below the *Section 6.4* limits.
(3) The following power supplies are all required to operate the DMD: VSS, VDD, VDDI, VOFFSET, VBIAS, and VRESET.
(4) All voltage values are with respect to the ground pins (VSS).
(5) VOFFSET supply transients must fall within specified maximum voltages.
(6) To prevent excess current, the supply voltage delta |VDDI – VDD| must be less than specified limit.
(7) To prevent excess current, the supply voltage delta |VBIAS – VOFFSET| must be less than specified limit.
(8) To prevent excess current, the supply voltage delta |VBIAS – VRESET| must be less than specified limit.
(9) LS_CLK must run as specified to ensure internal DMD timing for reset waveform commands.
(10) Refer to the SubLVDS timing requirements in *Section 6.7*.
(11) Simultaneous exposure of the DMD to the maximum *Section 6.4* for temperature and UV illumination will reduce device lifetime.
(12) The array temperature cannot be measured directly and must be computed analytically from the temperature measured at test point 1 (TP1) shown in Figure 7-1 and the Package Thermal Resistance using *Section 7.6*.
(13) Per Figure 6-1, the maximum operational array temperature should be derated based on the micromirror landed duty cycle that the DMD experiences in the end application. Refer to *Section 7.7* for a definition of micromirror landed duty cycle.
(14) Long-term is defined as the usable life of the device
(15) Short-term is the total cumulative time over the useful life of the device.
(16) Temperature delta is the highest difference between the ceramic test point 1 (TP1) and anywhere on the window edge shown in Figure 7-1. The window test points TP2 and TP3 shown in Figure 7-1 are intended to result in the worst case delta temperature. If a particular application causes another point on the window edge to result in a larger delta temperature, that point should be used.
(17) Window temperature is the highest temperature on the window edge shown in Figure 7-1. The locations of thermal test points TP2 and TP3 in Figure 7-1 are intended to measure the highest window edge temperature. If a particular application causes another point on the window edge to result in a larger delta temperature, that point should be used.
(18) The average over time (including storage and operating) that the device is not in the elevated dew point temperature range.
(19) Exposure to dew point temperatures in the elevated range during storage and operation should be limited to less than a total cumulative time of CT_{ELR}.
(20) The maximum marginal ray angle of the incoming illumination light at any point in the micromirror array, including Pond of Micromirrors (POM), should not exceed 55 degrees from the normal to the device array plane. The device window aperture has not necessarily been designed to allow incoming light at higher maximum angles to pass to the micromirrors, and the device performance has not been tested nor qualified at angles exceeding this. Illumination light exceeding this angle outside the micromirror array (including POM) will contribute to thermal limitations described in this document, and may negatively affect lifetime.

Copyright © 2022 Texas Instruments Incorporated

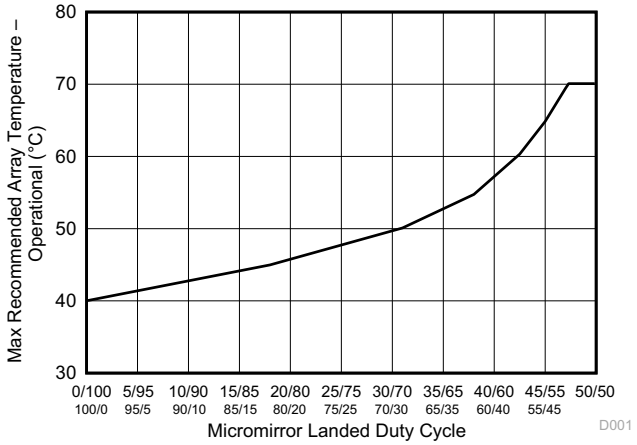


Figure 6-1. Maximum Recommended Array Temperature (Derating Curve)

Copyright © 2022 Texas Instruments Incorporated

6.5 Thermal Information

THERMAL METRIC[1]		DLP3010 FQK (LGA) 57 PINS	UNIT
Thermal resistance	Active area to test point 1 (TP1)[1]	5.4	°C/W

(1) The DMD is designed to conduct absorbed and dissipated heat to the back of the package. The cooling system must be capable of maintaining the package within the temperature range specified in the *Section 6.4*. The total heat load on the DMD is largely driven by the incident light absorbed by the active area; although other contributions include light energy absorbed by the window aperture and electrical power dissipation of the array. Optical systems should be designed to minimize the light energy falling outside the window clear aperture since any additional thermal load in this area can significantly degrade the reliability of the device.

6.6 Electrical Characteristics

Over operating free-air temperature range (unless otherwise noted)[10]

PARAMETER		TEST CONDITIONS[2]	MIN	TYP	MAX	UNIT
CURRENT						
I_{DD}	Supply current: VDD[3] [5]	VDD = 1.95 V			60.5	mA
		VDD = 1.8 V		54		
I_{DDI}	Supply current: VDDI[3] [5]	VDDI = 1.95 V			16.5	mA
		VDD = 1.8 V		11.3		
I_{OFFSET}	Supply current: VOFFSET[4] [6]	VOFFSET = 10.5 V			2.2	mA
		VOFFSET = 10 V		1.5		
I_{BIAS}	Supply current: VBIAS[4] [6]	VBIAS = 18.5 V			0.6	mA
		VBIAS = 18 V		0.3		
I_{RESET}	Supply current: VRESET[6]	VRESET = –14.5 V			2.4	mA
		VRESET = –14 V		1.7		
POWER[1]						
P_{DD}	Supply power dissipation: VDD[3] [5]	VDD = 1.95 V			118	mW
		VDD = 1.8 V		97.2		
P_{DDI}	Supply power dissipation: VDDI[3] [5]	VDDI = 1.95 V			32	mW
		VDD = 1.8 V		20		
P_{OFFSET}	Supply power dissipation: VOFFSET[4] [6]	VOFFSET = 10.5 V			23	mW
		VOFFSET = 10 V		15		
P_{BIAS}	Supply power dissipation: VBIAS[4] [6]	VBIAS = 18.5 V			11	mW
		VBIAS = 18 V		6		
P_{RESET}	Supply power dissipation: VRESET[6]	VRESET = –14.5 V			35	mW
		VRESET = –14 V		24		
P_{TOTAL}	Supply power dissipation: Total			162.2	219	mW
LPSDR INPUT[7]						
$V_{IH(DC)}$	DC input high voltage[9]		0.7 × VDD		VDD + 0.3	V
$V_{IL(DC)}$	DC input low voltage[9]		–0.3		0.3 × VDD	V
$V_{IH(AC)}$	AC input high voltage[9]		0.8 × VDD		VDD + 0.3	V
$V_{IL(AC)}$	AC input low voltage[9]		–0.3		0.2 × VDD	V
ΔV_T	Hysteresis ($V_{T+} – V_{T–}$)	Figure 6-12	0.1 × VDD		0.4 × VDD	V
I_{IL}	Low–level input current	VDD = 1.95 V; V_I = 0 V	–100			nA
I_{IH}	High–level input current	VDD = 1.95 V; V_I = 1.95 V			100	nA
LPSDR OUTPUT[8]						
V_{OH}	DC output high voltage	I_{OH} = –2 mA	0.8 × VDD			V
V_{OL}	DC output low voltage	I_{OL} = 2 mA			0.2 × VDD	V

Copyright © 2022 Texas Instruments Incorporated

6.6 Electrical Characteristics (continued)

Over operating free-air temperature range (unless otherwise noted)(10)

PARAMETER		TEST CONDITIONS(2)	MIN	TYP	MAX	UNIT
CAPACITANCE						
C_{IN}	Input capacitance LPSDR	f = 1 MHz			10	pF
	Input capacitance SubLVDS	f = 1 MHz			10	pF
C_{OUT}	Output capacitance	f = 1 MHz			10	pF
C_{RESET}	Reset group capacitance	f = 1 MHz; (720 × 160) micromirrors	200		220	pF

(1) The following power supplies are all required to operate the DMD: VSS, VDD, VDDI, VOFFSET, VBIAS, VRESET.
(2) All voltage values are with respect to the ground pins (VSS).
(3) To prevent excess current, the supply voltage delta |VDDI – VDD| must be less than specified limit.
(4) To prevent excess current, the supply voltage delta |VBIAS – VOFFSET| must be less than specified limit.
(5) Supply power dissipation based on non–compressed commands and data.
(6) Supply power dissipation based on 3 global resets in 200 µs.
(7) LPSDR specifications are for pins LS_CLK and LS_WDATA.
(8) LPSDR specification is for pin LS_RDATA.
(9) Low-speed interface is LPSDR and adheres to the Electrical Characteristics and AC/DC Operating Conditions table in JEDEC Standard No. 209B, *Low-Power Double Data Rate (LPDDR)* JESD209B.
(10) Device electrical characteristics are over *Section 6.4* unless otherwise noted.

6.7 Timing Requirements

Device electrical characteristics are over *Section 6.4* unless otherwise noted.

			MIN	NOM	MAX	UNIT
LPSDR						
t_r	Rise slew rate(1)	(30% to 80%) × VDD, Figure 6-3	1		3	V/ns
t_f	Fall slew rate(1)	(70% to 20%) × VDD, Figure 6-3	1		3	V/ns
t_r	Rise slew rate(2)	(20% to 80%) × VDD, Figure 6-4	0.25			V/ns
t_f	Fall slew rate(2)	(80% to 20%) × VDD, Figure 6-4	0.25			V/ns
t_c	Cycle time LS_CLK,	Figure 6-2	7.7	8.3		ns
$t_{W(H)}$	Pulse duration LS_CLK high	50% to 50% reference points, Figure 6-2	3.1			ns
$t_{W(L)}$	Pulse duration LS_CLK low	50% to 50% reference points, Figure 6-2	3.1			ns
t_{su}	Setup time	LS_WDATA valid before LS_CLK ↑, Figure 6-2	1.5			ns
t_h	Hold time	LS_WDATA valid after LS_CLK ↑, Figure 6-2	1.5			ns
t_{WINDOW}	Window time(1) (4)	Setup time + Hold time, Figure 6-2	3			ns
$t_{DERATING}$	Window time derating(1) (4)	For each 0.25 V/ns reduction in slew rate below 1 V/ns, Figure 6-6		0.35		ns
SubLVDS						
t_r	Rise slew rate	20% to 80% reference points, Figure 6-5	0.7	1		V/ns
t_f	Fall slew rate	80% to 20% reference points, Figure 6-5	0.7	1		V/ns
t_c	Cycle time DCLK,	Figure 6-7	1.79	1.85		ns
$t_{W(H)}$	Pulse duration DCLK high	50% to 50% reference points, Figure 6-7	0.79			ns
$t_{W(L)}$	Pulse duration DCLK low	50% to 50% reference points, Figure 6-7	0.79			ns
t_{su}	Setup time	D(0:3) valid before DCLK ↑ or DCLK ↓, Figure 6-7				
t_h	Hold time	D(0:3) valid after DCLK ↑ or DCLK ↓, Figure 6-7				

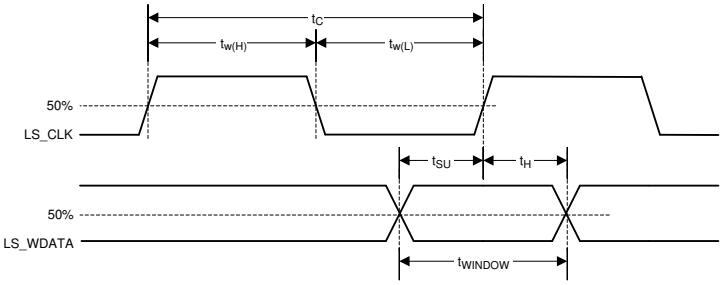
Copyright © 2022 Texas Instruments Incorporated

6.7 Timing Requirements (continued)

Device electrical characteristics are over *Section 6.4* unless otherwise noted.

			MIN	NOM	MAX	UNIT
t_{WINDOW}	Window time	Setup time + Hold time, Figure 6-7, Figure 6-8			0.3	ns
$t_{LVDS-ENABLE+REFGEN}$	Power-up receiver(3)				2000	ns

(1) Specification is for LS_CLK and LS_WDATA pins. Refer to LPSDR input rise slew rate and fall slew rate in Figure 6-3.
(2) Specification is for DMD_DEN_ARSTZ pin. Refer to LPSDR input rise and fall slew rate in Figure 6-4.
(3) Specification is for SubLVDS receiver time only and does not take into account commanding and latency after commanding.
(4) Window time derating example: 0.5-V/ns slew rate increases the window time by 0.7 ns, from 3 to 3.7 ns.



Low-speed interface is LPSDR and adheres to the *Section 6.6* and AC/DC Operating Conditions table in JEDEC Standard No. 209B, *Low Power Double Data Rate (LPDDR)* JESD209B.

Figure 6-2. LPSDR Switching Parameters

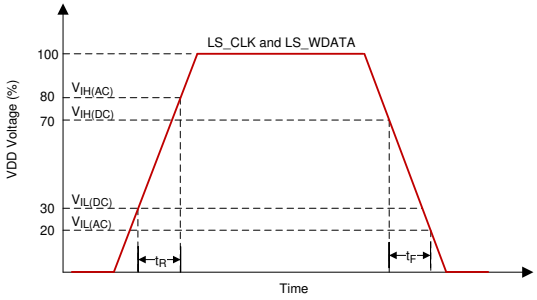


Figure 6-3. LPSDR Input Slew Rate

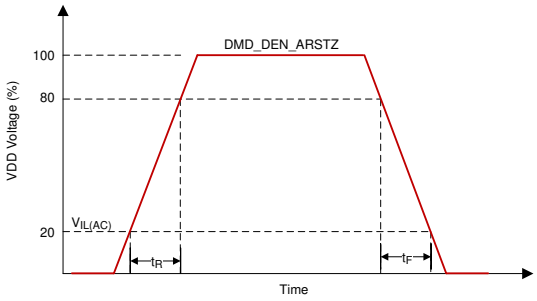


Figure 6-4. LPSDR Input Slew Rate

Copyright © 2022 Texas Instruments Incorporated

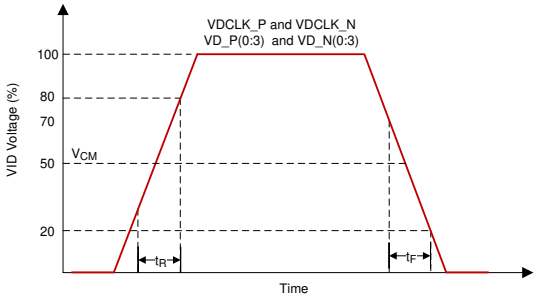


Figure 6-5. SubLVDS Input Rise and Fall Slew Rate

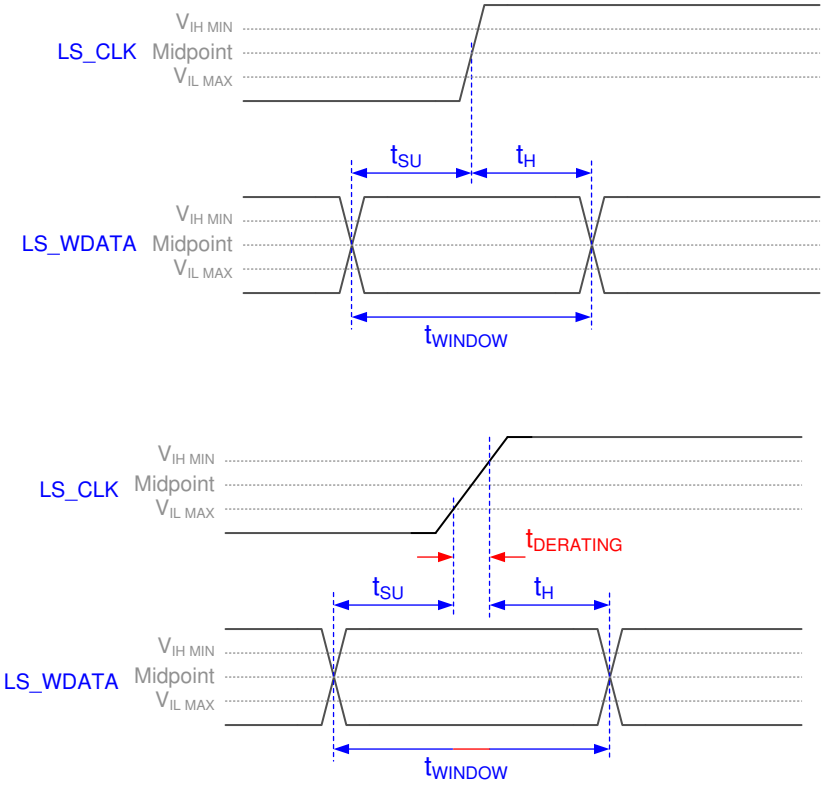


Figure 6-6. Window Time Derating Concept

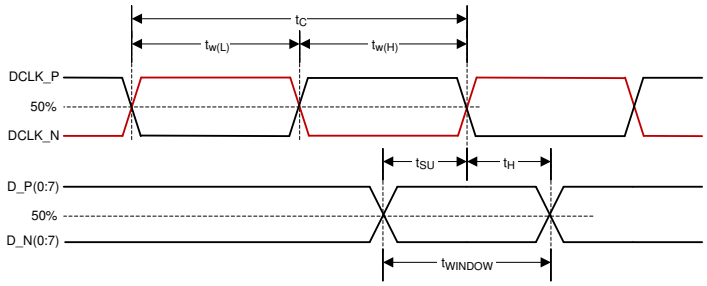
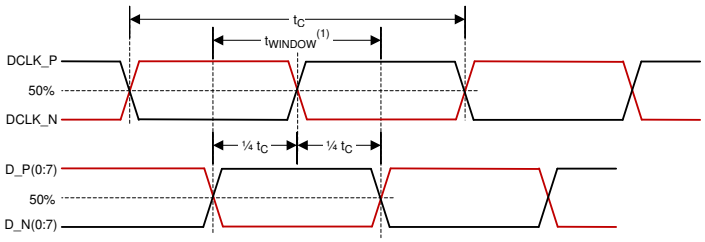


Figure 6-7. SubLVDS Switching Parameters



(1) High-speed training scan window
(2) Refer to *Section 7.3.3* for details

Figure 6-8. High-Speed Training Scan Window

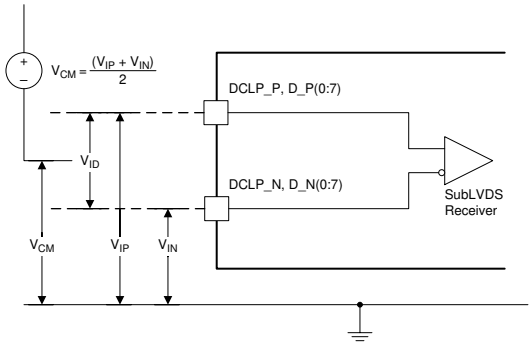


Figure 6-9. SubLVDS Voltage Parameters

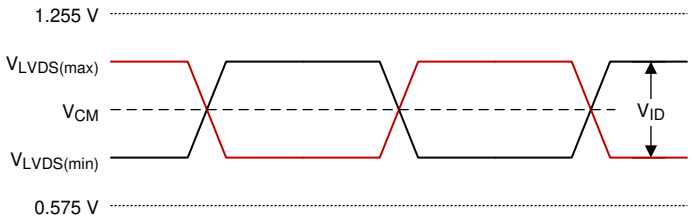


Figure 6-10. SubLVDS Waveform Parameters

$$V_{SubLVDS(max)} = V_{CM(max)} + ½ \times |V_{ID(max)}|$$

$$V_{SubLVDS(min)} = V_{CM(min)} - ½ \times |V_{ID(max)}|$$

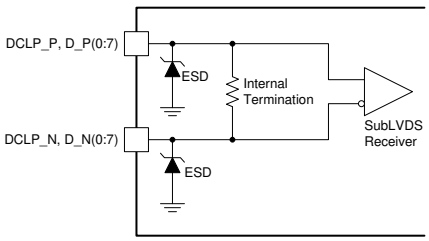


Figure 6-11. SubLVDS Equivalent Input Circuit

Copyright © 2022 Texas Instruments Incorporated

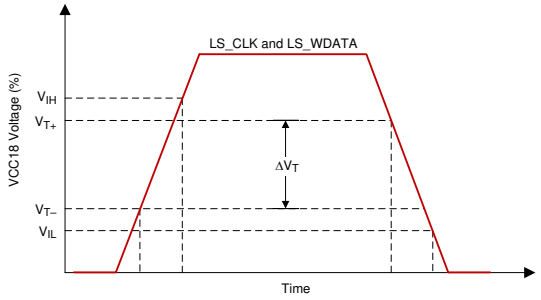


Figure 6-12. LPSDR Input Hysteresis

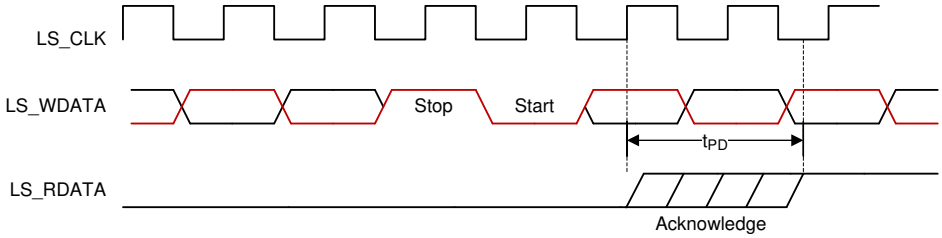
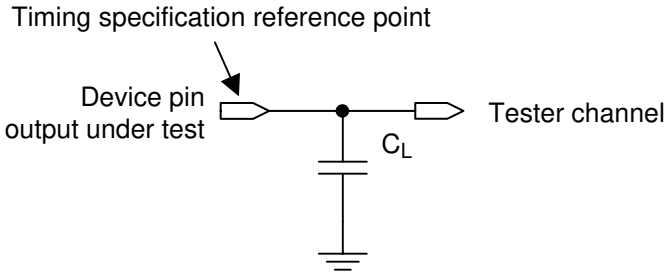


Figure 6-13. LPSDR Read Out



See *Section 7.3.4* for more information.

Figure 6-14. Test Load Circuit for Output Propagation Measurement

6.8 Switching Characteristics(1)

Over operating free-air temperature range (unless otherwise noted).

PARAMETER		TEST CONDITIONS	MIN	TYP	MAX	UNIT
t_{PD}	Output propagation, Clock to Q, rising edge of LS_CLK input to LS_RDATA output. Figure 6-13	C_L = 5 pF			11.1	ns
		C_L = 10 pF			11.3	ns
		C_L = 85 pF			15	ns
	Slew rate, LS_RDATA		0.5			V/ns
	Output duty cycle distortion, LS_RDATA		40%		60%	

(1) Device electrical characteristics are over *Section 6.4* unless otherwise noted.

Copyright © 2022 Texas Instruments Incorporated

6.9 System Mounting Interface Loads

PARAMETER		MIN	NOM	MAX	UNIT
Maximum system mounting interface load to be applied to the:	Electrical Interface Area (see Figure 6-15)			125	N
	Clamping and Thermal Interface Area (see Figure 6-15)			67	N

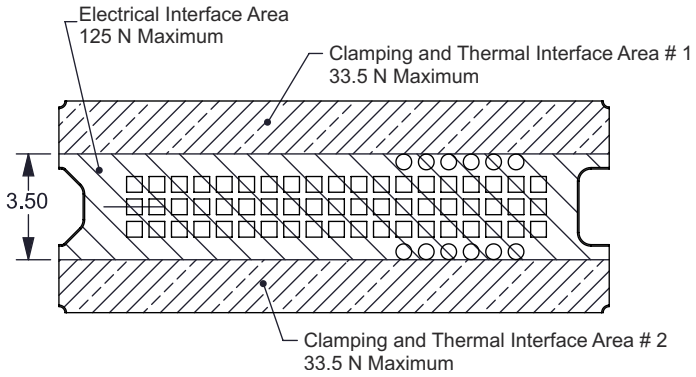


Figure 6-15. System Interface Loads

Copyright © 2022 Texas Instruments Incorporated

6.10 Physical Characteristics of the Micromirror Array

	PARAMETER		VALUE	UNIT
	Number of active columns	See Figure 6-16	1280	micromirrors
	Number of active rows	See Figure 6-16	720	micromirrors
ε	Micromirror (pixel) pitch	See Figure 6-17	5.4	µm
	Micromirror active array width	Micromirror pitch × number of active columns; see Figure 6-16	6.912	mm
	Micromirror active array height	Micromirror pitch × number of active rows; see Figure 6-16	3.888	mm
	Micromirror active border	Pond of micromirror (POM)(1)	20	micromirrors/ side

(1) The structure and qualities of the border around the active array includes a band of partially functional micromirrors called the POM. These micromirrors are structurally and/or electrically prevented from tilting toward the bright or ON state, but still require an electrical bias to tilt toward OFF.

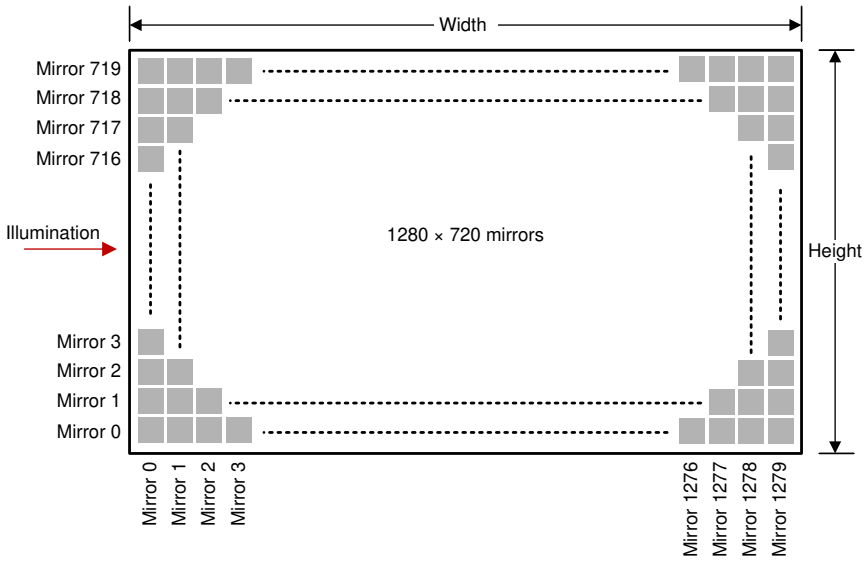


Figure 6-16. Micromirror Array Physical Characteristics

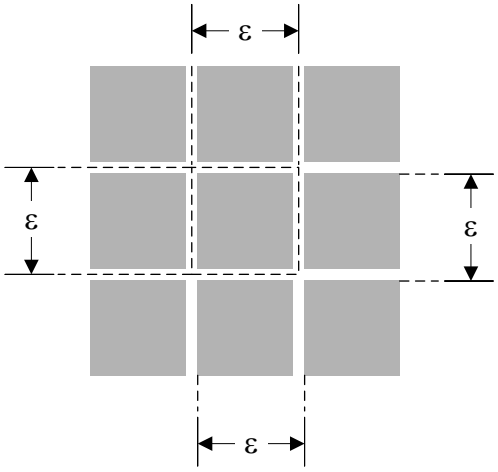


Figure 6-17. Mirror (Pixel) Pitch

Copyright © 2022 Texas Instruments Incorporated

6.11 Micromirror Array Optical Characteristics

PARAMETER		TEST CONDITIONS	MIN	NOM	MAX	UNIT
Micromirror tilt angle		DMD landed state(1)		17		degree
Micromirror tilt angle tolerance(2) (3) (4) (5)			–1.4		1.4	degree
Micromirror tilt direction (6) (7)		Landed ON state		180		degree
		Landed OFF state		270		
Micromirror crossover time(8)		Typical performance		1	3	µs
Micromirror switching time(9)		Typical performance	10			
Image performance(10)	Bright pixel(s) in active area (11)	Gray 10 Screen (12)			0	micromirrors
	Bright pixel(s) in the POM (13)	Gray 10 Screen (12)			1	
	Dark pixel(s) in the active area (14)	White Screen			4	
	Adjacent pixel(s) (15)	Any Screen			0	
	Unstable pixel(s) in active area (16)	Any Screen			0	

(1) Measured relative to the plane formed by the overall micromirror array.
(2) Additional variation exists between the micromirror array and the package datums.
(3) Represents the landed tilt angle variation relative to the nominal landed tilt angle.
(4) Represents the variation that can occur between any two individual micromirrors, located on the same device or located on different devices.
(5) For some applications, it is critical to account for the micromirror tilt angle variation in the overall system optical design. With some system optical designs, the micromirror tilt angle variation within a device may result in perceivable non-uniformities in the light field reflected from the micromirror array. With some system optical designs, the micromirror tilt angle variation between devices may result in colorimetry variations, system efficiency variations, or system contrast variations.
(6) When the micromirror array is landed (not parked), the tilt direction of each individual micromirror is dictated by the binary contents of the CMOS memory cell associated with each individual micromirror. A binary value of 1 results in a micromirror landing in the ON state direction. A binary value of 0 results in a micromirror landing in the OFF state direction. See Figure 6-18.
(7) Micromirror tilt direction is measured as in a typical polar coordinate system: Measuring counter-clockwise from a 0° reference which is aligned with the +X Cartesian axis.
(8) The time required for a micromirror to nominally transition from one landed state to the opposite landed state.
(9) The minimum time between successive transitions of a micromirror.
(10) Conditions of Acceptance: All DMD image quality returns will be evaluated using the following projected image test conditions:
Test set degamma shall be linear
Test set brightness and contrast shall be set to nominal
The diagonal size of the projected image shall be a minimum of 20 inches
The projections screen shall be 1X gain
The projected image shall be inspected from a 38 inch minimum viewing distance
The image shall be in focus during all image quality tests
(11) Bright pixel definition: A single pixel or mirror that is stuck in the ON position and is visibly brighter than the surrounding pixels
(12) Gray 10 screen definition: All areas of the screen are colored with the following settings:
Red = 10/255
Green = 10/255
Blue = 10/255
(13) POM definition: Rectangular border of off-state mirrors surrounding the active area
(14) Dark pixel definition: A single pixel or mirror that is stuck in the OFF position and is visibly darker than the surrounding pixels
(15) Adjacent pixel definition: Two or more stuck pixels sharing a common border or common point, also referred to as a cluster
(16) Unstable pixel definition: A single pixel or mirror that does not operate in sequence with parameters loaded into memory. The unstable pixel appears to be flickering asynchronously with the image

Copyright © 2022 Texas Instruments Incorporated

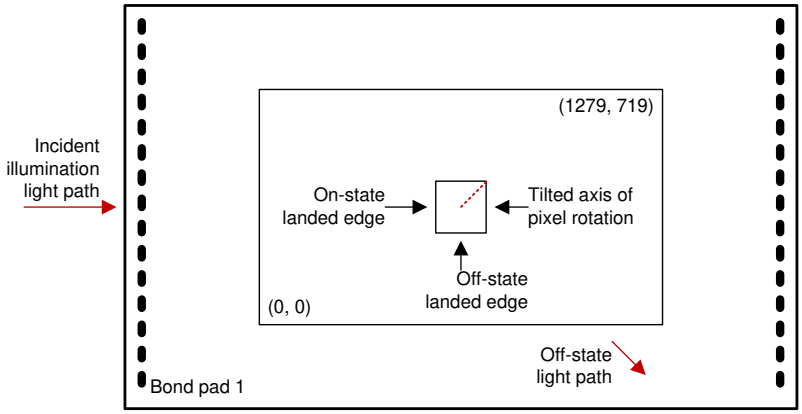


Figure 6-18. Landed Pixel Orientation and Tilt

6.12 Window Characteristics

PARAMETER[3]		MIN	NOM	MAX	UNIT
Window material designation			Corning Eagle XG		
Window refractive index	at wavelength 546.1 nm		1.5119		
Window aperture[1]				See [1]	
Illumination overfill[2]				See [2]	
Window transmittance, single-pass through both surfaces and glass	Minimum within the wavelength range 420 to 680 nm. Applies to all angles 0° to 30° AOI.	97%			
Window Transmittance, single-pass through both surfaces and glass	Average over the wavelength range 420 to 680 nm. Applies to all angles 30° to 45° AOI.	97%			

(1) See the package mechanical characteristics for details regarding the size and location of the window aperture.
(2) The active area of the 7212-313BK device is surrounded by an aperture on the inside of the DMD window surface that masks structures of the DMD device assembly from normal view. The aperture is sized to anticipate several optical conditions. Overfill light illuminating the area outside the active array can scatter and create adverse effects to the performance of an end application using the DMD. The illumination optical system should be designed to limit light flux incident outside the active array to less than 10% of the average flux level in the active area. Depending on the particular system's optical architecture and assembly tolerances, the amount of overfill light on the outside of the active array may cause system performance degradation.
(3) See *Section 7.5* for more information.

6.13 Chipset Component Usage Specification

The 7212-313BK is a component of one or more TI DLP® chipsets. Reliable function and operation of the 7212-313BK requires that it be used in conjunction with the other components of the applicable DLP chipset, including those components that contain or implement TI DMD control technology. TI DMD control technology is the TI technology and devices for operating or controlling a DLP DMD.

Note

TI assumes no responsibility for image quality artifacts or DMD failures caused by optical system operating conditions exceeding limits described previously.

6.14 Software Requirements

CAUTION

The 7212-313BK DMD has mandatory software requirements. Refer to *Software Requirements for TI DLP®Pico™ TRP Digital Micromirror Devices* application report for additional information. Failure to use the specified software will result in failure at power up.

Copyright © 2022 Texas Instruments Incorporated

7 Detailed Description

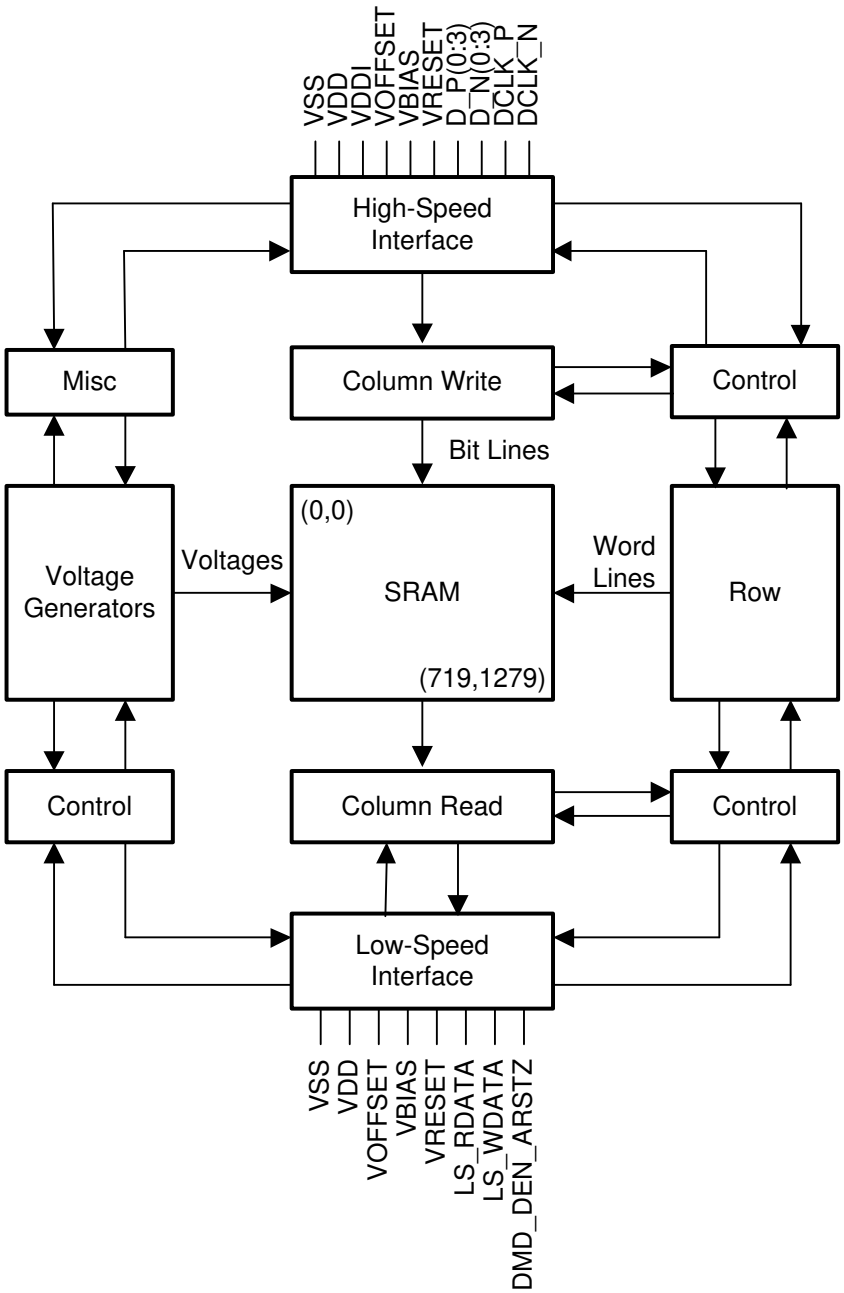
7.1 Overview

The 7212-313BK DMD is a 0.3 inch diagonal spatial light modulator of aluminum micromirrors. Pixel array size is 1280 columns by 720 rows in a square grid pixel arrangement. The electrical interface is Sub Low Voltage Differential Signaling (SubLVDS) data.

This DMD is part of the chipset that includes the 7212-313BK DMD, DLPC3478 display and light controller and DLPA200x/DLPA300x PMIC/LED driver. To ensure reliable operation, this DMD must always be used with DLPC3478 display and light controller and DLPA200x/DLPA300x PMIC/LED driver.

Copyright © 2022 Texas Instruments Incorporated

7.2 Functional Block Diagram



A. Details omitted for clarity
B. Orientation is not representative of optical system
C. Scale is not representative of layout

Copyright © 2022 Texas Instruments Incorporated

7.3 Feature Description

7.3.1 Power Interface

The power management IC, DLPA200x/DLPA300x, contains 3 regulated DC supplies for the DMD reset circuitry: VBIAS, VRESET and VOFFSET, as well as the 2 regulated DC supplies for the DLPC3478 controller.

7.3.2 Low-Speed Interface

The Low Speed Interface handles instructions that configure the DMD and control reset operation. LS_CLK is the low–speed clock, and LS_WDATA is the low speed data input.

7.3.3 High-Speed Interface

The purpose of the high-speed interface is to transfer pixel data rapidly and efficiently, making use of high speed DDR transfer and compression techniques to save power and time. The high-speed interface is composed of differential SubLVDS receivers for inputs, with a dedicated clock.

7.3.4 Timing

The data sheet provides timing test results at the device pin. For output timing analysis, the tester pin electronics and its transmission line effects must be considered. Test Load Circuit for Output Propagation Measurement shows an equivalent test load circuit for the output under test. Timing reference loads are not intended as a precise representation of any particular system environment or depiction of the actual load presented by a production test. TI recommends that system designers use IBIS or other simulation tools to correlate the timing reference load to a system environment. The load capacitance value stated is intended for characterization and measurement of AC timing signals only. This load capacitance value does not indicate the maximum load the device is capable of driving.

7.4 Device Functional Modes

DMD functional modes are controlled by the DLPC3478 controller. See the DLPC3478 controller data sheet or contact a TI applications engineer.

7.5 Optical Interface and System Image Quality Considerations

Note

TI assumes no responsibility for image quality artifacts or DMD failures caused by optical system operating conditions exceeding limits described previously.

7.5.1 Optical Interface and System Image Quality

TI assumes no responsibility for end-equipment optical performance. Achieving the desired end-equipment optical performance involves making trade-offs between numerous component and system design parameters. Optimizing system optical performance and image quality strongly relate to optical system design parameter trades. Although it is not possible to anticipate every conceivable application, projector image quality and optical performance is contingent on compliance to the optical system operating conditions described in the following sections.

7.5.1.1 Numerical Aperture and Stray Light Control

The angle defined by the numerical aperture of the illumination and projection optics at the DMD optical area is typically the same. Ensure this angle does not exceed the nominal device micromirror tilt angle unless appropriate apertures are added in the illumination or projection pupils to block out flat-state and stray light from the projection lens. The micromirror tilt angle defines DMD capability to separate the "ON" optical path from any other light path, including undesirable flat–state specular reflections from the DMD window, DMD border structures, or other system surfaces near the DMD such as prism or lens surfaces. If the numerical aperture exceeds the micromirror tilt angle, or if the projection numerical aperture angle is more than two degrees larger than the illumination numerical aperture angle (and vice versa), contrast degradation and objectionable artifacts in the display border and/or active area may occur.

Copyright © 2022 Texas Instruments Incorporated

7.5.1.2 Pupil Match

The optical and image quality specifications assume that the exit pupil of the illumination optics is nominally centered within 2° of the entrance pupil of the projection optics. Misalignment of pupils can create objectionable artifacts in the display border and/or active area. These artifacts may require additional system apertures to control, especially if the numerical aperture of the system exceeds the pixel tilt angle.

7.5.1.3 Illumination Overfill

The active area of the device is surrounded by an aperture on the inside DMD window surface that masks structures of the DMD chip assembly from normal view, and is sized to anticipate several optical operating conditions. Overfill light illuminating the window aperture can create artifacts from the edge of the window aperture opening and other surface anomalies that may be visible on the screen. Be sure to design an illumination optical system that limits light flux incident anywhere on the window aperture from exceeding approximately 10% of the average flux level in the active area. Depending on the particular optical architecture, overfill light may require further reduction below the suggested 10% level in order to be acceptable.

7.6 Micromirror Array Temperature Calculation

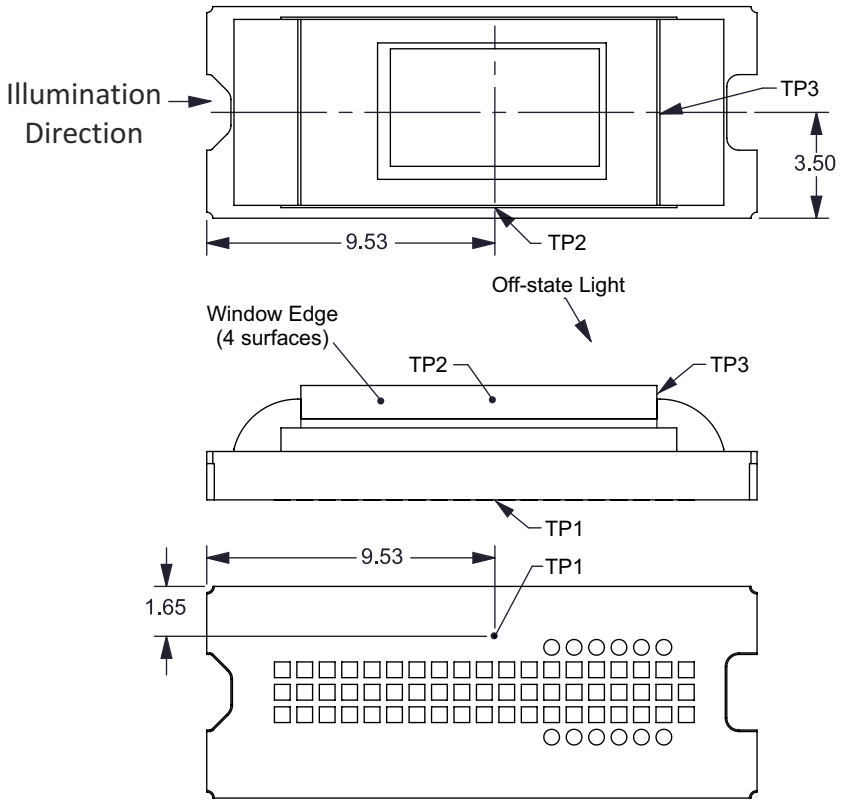


Figure 7-1. DMD Thermal Test Points

Micromirror array temperature can be computed analytically from measurement points on the outside of the package, the ceramic package thermal resistance, the electrical power dissipation, and the illumination heat load. The relationship between micromirror array temperature and the reference ceramic temperature is provided by the following equations:

$$T_{ARRAY} = T_{CERAMIC} + (Q_{ARRAY} \times R_{ARRAY-TO-CERAMIC}) \quad (1)$$

$$Q_{ARRAY} = Q_{ELECTRICAL} + Q_{ILLUMINATION} \quad (2)$$

$$Q_{ILLUMINATION} = (C_{L2W} \times SL) \quad (3)$$

Copyright © 2022 Texas Instruments Incorporated

where

- T_{ARRAY} = Computed DMD array temperature (°C)
- $T_{CERAMIC}$ = Measured ceramic temperature (°C), TP1 location in DMD Thermal Test Points
- $R_{ARRAY–TO–CERAMIC}$ = DMD package thermal resistance from array to outside ceramic (°C/W) specified in *Thermal Information*
- Q_{ARRAY} = Total DMD power; electrical plus absorbed (calculated) (W)
- $Q_{ELECTRICAL}$ = Nominal DMD electrical power dissipation (W)
- C_{L2W} = Conversion constant for screen lumens to absorbed optical power on the DMD (W/lm) specified below
- SL = Measured ANSI screen lumens (lm)

The electrical power dissipation of the DMD varies and depends on the voltages, data rates and operating frequencies. Use a nominal electrical power dissipation of 0.1 W to calculate array temperature. Absorbed optical power from the illumination source varies and depends on the operating state of the micromirrors and the intensity of the light source. Equation 1 through Equation 1 are valid for a 1-chip DMD system with total projection efficiency through the projection lens from DMD to the screen of 87%.

The conversion constant CL2W is based on the DMD micromirror array characteristics. The conversion constant assumes a spectral efficiency of 300 lm/W for the projected light and illumination distribution of 83.7% on the DMD active array, and 16.3% on the DMD array border and window aperture. The conversion constant is calculated to be 0.00266 W/lm.

The following is a sample calculation for typical projection application:

$T_{CERAMIC}$ = 55°C (measured)

SL = 300 lm (measured)

$Q_{ELECTRICAL}$ = 0.100 W

CL2W = 0.00266 W/lm

Q_{ARRAY} = 0.100 W + (0.00266 W/lm × 300 lm) = 0.898 W

T_{ARRAY} = 55°C + (0.898 W × 5.4°C/W) = 59.85°C

7.7 Micromirror Landed-On/Landed-Off Duty Cycle

7.7.1 Definition of Micromirror Landed-On and Landed-Off Duty Cycle

The micromirror landed-on/landed-off duty cycle (landed duty cycle) denotes the amount of time (as a percentage) that an individual micromirror is landed in the ON state versus the amount of time the same micromirror is landed in the OFF state.

As an example, a landed duty cycle of 75/25 indicates that the referenced pixel is in the ON state 75% of the time (and in the OFF state 25% of the time), whereas 25/75 indicates that the pixel is in the OFF state 75% of the time. Likewise, 50/50 indicates that the pixel is ON 50% of the time and OFF 50% of the time.

When assessing landed duty cycle, the time spent switching from the current state to the opposite state is considered negligible and is thus ignored.

Because a micromirror can only be landed in one state or the other (ON or OFF), the two numbers (percentages) nominally add to 100.In practice, image processing algorithms in the DLP chipset can result a total of less that 100.

7.7.2 Landed Duty Cycle and Useful Life of the DMD

Knowing the long-term average landed duty cycle (of the end product or application) is important because subjecting all (or a portion) of the DMD's micromirror array (also called the active array) to an asymmetric landed duty cycle for a prolonged period of time can reduce the DMD's usable life.

It is the symmetry or asymmetry of the landed duty cycle that is relevant. The symmetry of the landed duty cycle is determined by how close the two numbers (percentages) are to being equal. For example, a landed duty cycle of 50/50 is perfectly symmetrical whereas a landed duty cycle of 100/0 or 0/100 is perfectly asymmetrical.

Copyright © 2022 Texas Instruments Incorporated

7.7.3 Landed Duty Cycle and Operational DMD Temperature

Operational DMD temperature and landed duty cycle interact to affect the usable life of the DMD. This interaction can be used to reduce the impact that an asymmetrical landed duty cycle has on the useable life of the DMD. Figure 6-1 describes this relationship. The importance of this curve is that:

- All points along this curve represent the same usable life.
- All points above this curve represent lower usable life (and the further away from the curve, the lower the usable life).
- All points below this curve represent higher usable life (and the further away from the curve, the higher the usable life).

In practice, this curve specifies the maximum operating DMD temperature that the DMD should be operated at for a give long-term average landed duty cycle.

7.7.4 Estimating the Long-Term Average Landed Duty Cycle of a Product or Application

During a given period of time, the landed duty cycle of a given pixel depends on the image content being displayed by that pixel.

In the simplest case for example, when the system displays pure-white on a given pixel for a given time period, that pixel operates very close to a 100/0 landed duty cycle during that time period. Likewise, when the system displays pure-black, the pixel operates very close to a 0/100 landed duty cycle.

Between the two extremes (ignoring for the moment color and any image processing that may be applied to an incoming image), the landed duty cycle tracks one-to-one with the gray scale value, as shown in Table 7-1.

Table 7-1. Grayscale Value and Landed Duty Cycle

Grayscale Value	Nominal Landed Duty Cycle
0%	0/100
10%	10/90
20%	20/80
30%	30/70
40%	40/60
50%	50/50
60%	60/40
70%	70/30
80%	80/20
90%	90/10
100%	100/0

To account for color rendition (and continuing to ignore image processing for this example) requires knowing both the color intensity (from 0% to 100%) for each constituent primary color (red, green, and/or blue) for the given pixel as well as the color cycle time for each primary color, where *color cycle time* describes the total percentage of the frame time that a given primary must be displayed in order to achieve the desired white point.

During a given period of time, the nominal landed duty cycle of a given pixel can be calculated as shown in Equation 4:

$$\text{Landed Duty Cycle} = (\text{Red\_Cycle\_\%} \times \text{Red\_Scale\_Value}) + (\text{Green\_Cycle\_\%} \times \text{Green\_Scale\_Value}) + (\text{Blue\_Cycle\_\%} \times \text{Blue\_Scale\_Value}) \quad (4)$$

where

Copyright © 2022 Texas Instruments Incorporated

- Red_Cycle_% represents the percentage of the frame time that red displays to achieve the desired white point
- Green_Cycle_% represents the percentage of the frame time that green displays to achieve the desired white point
- Blue_Cycle_% represents the percentage of the frame time that blue displays to achieve the desired white point

For example, assume that the ratio of red, green and blue color cycle times are as listed in Table 7-2 (in order to achieve the desired white point) then the resulting nominal landed duty cycle for various combinations of red, green, blue color intensities are as shown in Table 7-3.

Table 7-2. Example Landed Duty Cycle for Full-Color Pixels

Red Cycle Percentage	Green Cycle Percentage	Blue Cycle Percentage
50%	20%	30%

Table 7-3. Color Intensity Combinations

Red Scale Value	Green Scale Value	Blue Scale Value	Nominal Landed Duty Cycle
0%	0%	0%	0/100
100%	0%	0%	50/50
0%	100%	0%	20/80
0%	0%	100%	30/70
12%	0%	0%	6/94
0%	35%	0%	7/93
0%	0%	60%	18/82
100%	100%	0%	70/30
0%	100%	100%	50/50
100%	0%	100%	80/20
12%	35%	0%	13/87
0%	35%	60%	25/75
12%	0%	60%	24/76
100%	100%	100%	100/0

The last factor to consider when estimating the landed duty cycle is any applied image processing. In the DLPC34xx controller family, the two functions which influence the actual landed duty cycle are Gamma and IntelliBright™, and bitplane sequencing rules.

Gamma is a power function of the form Output_Level = A × Input_Level^{Gamma}, where A is a scaling factor that is typically set to 1.

In the DLPC34xx controller family, gamma is applied to the incoming image data on a pixel-by-pixel basis. A typical gamma factor is 2.2, which transforms the incoming data as shown in Figure 7-2.

Figure 7-2. Example of Gamma = 2.2

As shown in Figure 7-2, when the gray scale value of a given input pixel is 40% (before gamma is applied), then gray scale value is 13% after gamma is applied. Because gamma has a direct impact on the displayed gray scale level of a pixel, it also has a direct impact on the landed duty cycle of a pixel.

Copyright © 2022 Texas Instruments Incorporated

The IntelliBright algorithms content adaptive illumination control (CAIC) and local area brightness boost (LABB) also apply transform functions on the gray scale level of each pixel.

But while amount of gamma applied to every pixel (of every frame) is constant (the exponent, gamma, is constant), CAIC and LABB are both adaptive functions that can apply a different amounts of either boost or compression to every pixel of every frame.

Be sure to account for any image processing which occurs before the controller.

7.7.5

The IntelliBright algorithm content adaptive illumination control (CAIC) and local area brightness boost (LABB) also apply transform functions on the gray scale level of each pixel.

But while the amount of gamma correction applied to every pixel (of every frame) is constant (the exponent, gamma, is constant), CAIC and LABB are both adaptive functions that can apply a different amounts of either boost or compression to every pixel of every frame.

The CAIC and LABB algorithms receive no information regarding any previous gain or boost processing. In cases where the application performs any processing of the input data before the image reaches the DLPC3478 controller, unexpected behavior such as saturation may occur.

Copyright © 2022 Texas Instruments Incorporated

8 Application and Implementation

Note

Information in the following applications sections is not part of the TI component specification, and TI does not warrant its accuracy or completeness. TI's customers are responsible for determining suitability of components for their purposes, as well as validating and testing their design implementation to confirm system functionality.

8.1 Application Information

The DMDs are spatial light modulators which reflect incoming light from an illumination source to one of two directions, with the primary direction being into a projection or collection optic. Each application depends primarily on the optical architecture of the system and the format of the data coming into the DLPC3478 controller. The new high-tilt pixel in the side-illuminated DMD increases brightness performance and enables a smaller system electronics footprint for thickness constrained applications. Applications include

- Integrated display and 3D depth capture
  - Smart phone, tablets, laptop, camera
  - Battery-powered mobile accessory
- 3D depth capture: 3D camera, 3D reconstruction, AR/VR, dental scanner
- 3D machine vision: robotics, metrology, in-line inspection (AOI)
- 3D biometrics: facial and finger print recognition
- Light exposure: 3D printers, programmable spatial and temporal light exposure

DMD power-up and power-down sequencing is strictly controlled by the DLPA200x/DLPA300x. Refer to *Section 9* for power-up and power-down specifications. 7212-313BK DMD reliability is specified when used with DLPC3478 controller and DLPA200x/DLPA300x PMIC/LED driver only.

8.2 Typical Application

DLP3010LC DMD with DLPC3478 controller enables high accuracy and very small form factor 3D depth scanner products. Figure 8-1 shows a typical 3D depth scanner system block diagram using external pattern streaming mode.

Copyright © 2022 Texas Instruments Incorporated

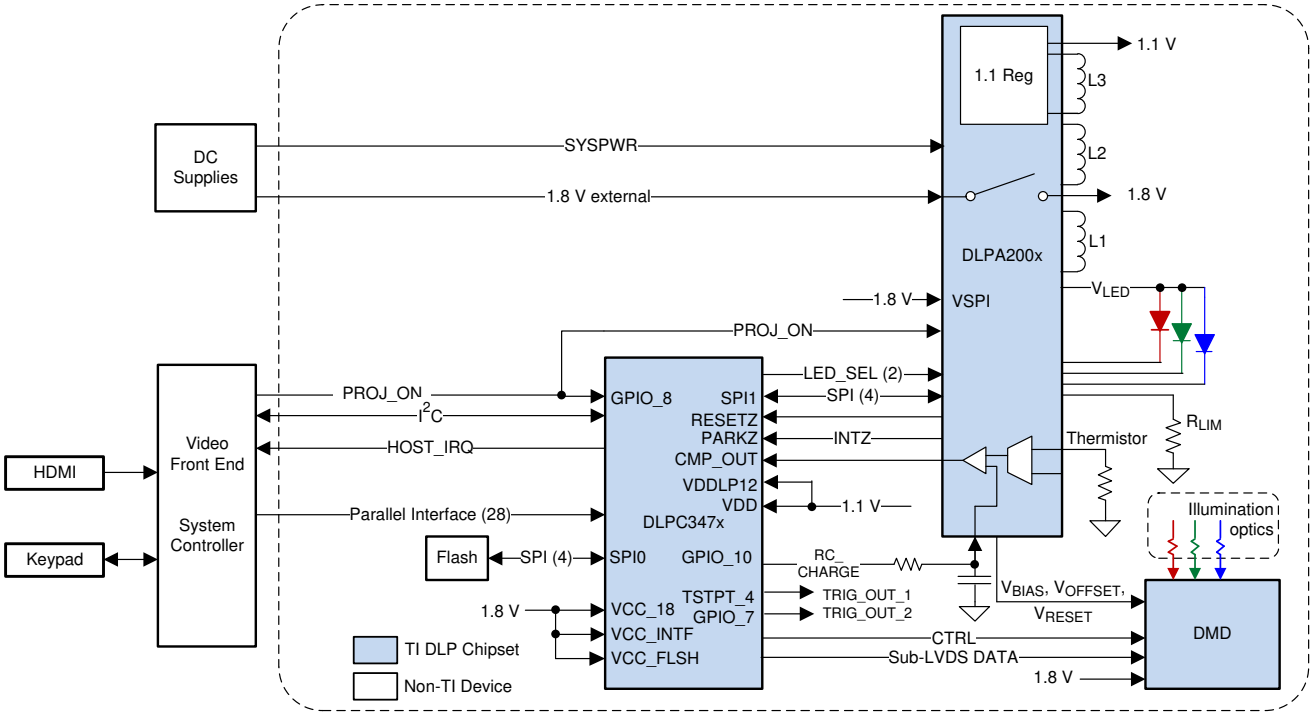


Figure 8-1. Typical Application

8.2.1 Design Requirements

A high-accuracy 3D depth scanner product can be created by using a DLP chipset comprised of DLP3010 DMD, DLPC3478 controller and DLPA200x or DLPA300x PMIC/LED driver. The DLPC3478 simplifies the pattern generation, the DLPA200x or DLPA300x provides the needed analog functions and the DMD displays the required patterns for accurate 3D depth scanning.

In addition to the three DLP devices in the chipset, other IC components may be needed. At a minimum, this design requires a flash device to store the software and firmware to control the DLPC3478 .

Red, green, and blue LEDs typically supply the illumination light that is applied to the DMD. These LEDs are often contained in three separate packages, but sometimes more than one color of LED die may be in the same package to reduce the overall size of the pico-projector. In addition to LEDs, other light sources like laser diodes, vertical-cavity surface-emitting laser (VCSEL) are also supported.

The parallel interface connects the DLPC3478 controller to the host processing for receiving patterns or video data. Connect an I^2C interface to the host processor to send commands to the DLPC3478 controller. The battery (SYSPWR) and a regulated 1.8-V supply are the only power supplies needed external to the projector in case of DLPA200x. The DLPA300x supplies 1.8 V without external regulator. A single signal (PROJ_ON) controls the entire DLP system power. When PROJ_ON is high, the DLP system turns on and when PROJ_ON is low, the DLPC3478 turns off. When the DLPC3478 is off, the DLP system draws only a few microamperes of current on SYSPWR. When PROJ_ON is low, the 1.8-V power supply can remain at 1.8 V for use by other sub systems. When PROJ_ON is low, the DLPA200x or DLPA300x draws no current on the 1.8-V supply.

8.2.2 Detailed Design Procedure

For more information on connecting the DLPC3478, the DLPA200x/DLPA300x, and the DMD, see the reference design schematic. Based on the reference schematic a small circuit board can be created. An example small board layout is included in the reference design data base. Layout guidelines should be followed to achieve a reliable projector.

Copyright © 2022 Texas Instruments Incorporated

The optical engine that has the LED packages and the DMD mounted to it is typically supplied by an optical OEM who specializes in designing optics for DLP projectors.

8.2.3 Application Curve

This device drives current time-sequentially though the LEDs. As the LED currents through the red, green, and blue LEDs increases, the brightness of the projector increases. This increase is somewhat non-linear, and the curve for typical white screen lumens changes with LED currents as shown in Figure 8-2. For the LED currents shown, assumed that the same current amplitude is applied to the red, green, and blue.

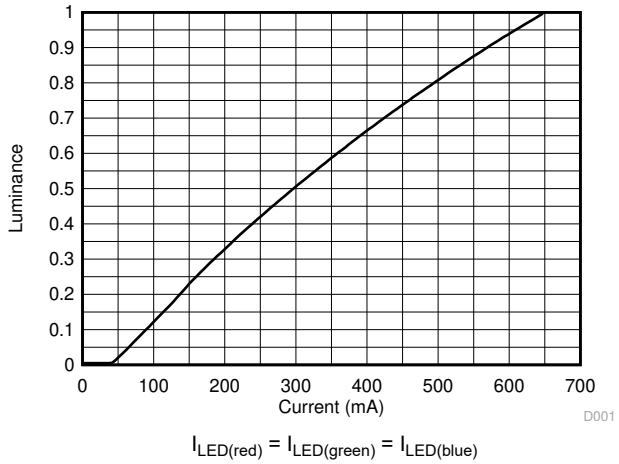


Figure 8-2. Luminance vs Current

9 Power Supply Recommendations

The following power supplies are all required to operate the DMD:

- V_{SS}
- V_{BIAS}
- V_{DD}
- V_{DDI}
- V_{OFFSET}
- V_{RESET}

DMD power-up and power-down sequencing is strictly controlled by the DLPAxxxx device.

CAUTION

For reliable operation of the DMD, the following power supply sequencing requirements must be followed. Failure to adhere to any of the prescribed power-up and power-down requirements may affect device reliability. See the DMD power supply sequencing requirements in Figure 9-1.

V_{BIAS}, V_{DD}, V_{DDI}, V_{OFFSET}, and V_{RESET} power supplies must be coordinated during power-up and power-down operations. Failure to meet any of the below requirements will result in a significant reduction in the DMD reliability and lifetime. Common ground V_{SS} must also be connected.

9.1 DMD Power Supply Power-Up Procedure

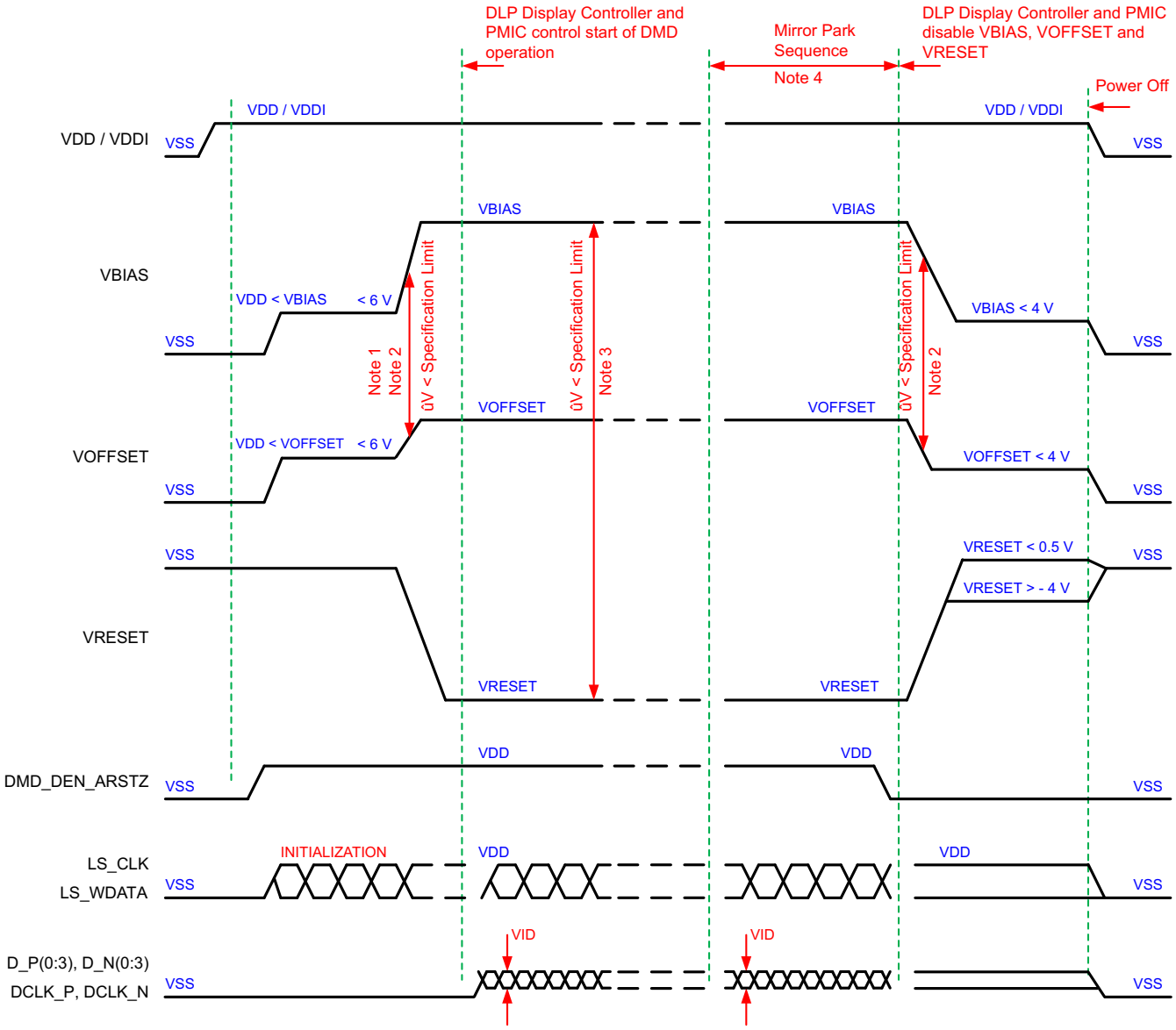
- During power-up, V_{DD} and V_{DDI} must always start and settle before V_{OFFSET}, V_{BIAS}, and V_{RESET} voltages are applied to the DMD.
- During power-up, it is a strict requirement that the voltage difference between V_{BIAS} and V_{OFFSET} must be within the specified limit shown in *Section 6.4*. Refer to Table 9-1 for power-up delay requirements.
- During power-up, there is no requirement for the relative timing of V_{RESET} with respect to V_{BIAS} and V_{OFFSET}.
- Power supply slew rates during power-up are flexible, provided that the transient voltage levels follow the requirements specified in *Section 6.1*, in *Section 6.4*, and in Section 9.3.
- During power-up, LPSDR input pins must not be driven high until after V_{DD} /V_{DDI} have settled at operating voltages listed in *Section 6.4*.

9.2 DMD Power Supply Power-Down Procedure

- Power-down sequence is the reverse order of the previous power-up sequence. During power-down, V_{DD} and V_{DDI} must be supplied until after V_{BIAS}, V_{RESET}, and V_{OFFSET} are discharged to within 4 V of ground.
- During power-down, it is a strict requirement that the voltage difference between V_{BIAS} and V_{OFFSET} must be within the specified limit shown in *Section 6.4*.
- During power-down, there is no requirement for the relative timing of V_{RESET} with respect to V_{BIAS} and V_{OFFSET}.
- Power supply slew rates during power-down are flexible, provided that the transient voltage levels follow the requirements specified in *Section 6.1*, in*Section 6.4*, and in Section 9.3.
- During power-down, LPSDR input pins must be less than V_{DD} /V_{DDI} specified in *Section 6.4*.

Copyright © 2022 Texas Instruments Incorporated

9.3 Power Supply Sequencing Requirements



A. Refer to Table 9-1 and Figure 9-2 for critical power-up sequence delay requirements.

B. To prevent excess current, the supply voltage delta $|V_{BIAS} – V_{OFFSET}|$ must be less than specified in Section 6.4. OEMs may find that the most reliable way to ensure this is to power V_{OFFSET} prior to V_{BIAS} during power-up and to remove V_{BIAS} prior to V_{OFFSET} during power-down. Refer to Table 9-1 and Figure 9-2 for power-up delay requirements.

C. To prevent excess current, the supply voltage delta $|V_{BIAS} – V_{RESET}|$ must be less than specified limit shown in Section 6.4.

D. When system power is interrupted, the ASIC driver initiates hardware power-down that disables V_{BIAS}, V_{RESET} and V_{OFFSET} after the Micromirror Park Sequence. Software power-down disables V_{BIAS}, V_{RESET}, and V_{OFFSET} after the Micromirror Park Sequence through software control.

E. Drawing is not to scale and details are omitted for clarity.

Figure 9-1. Power Supply Sequencing Requirements (Power Up and Power Down)

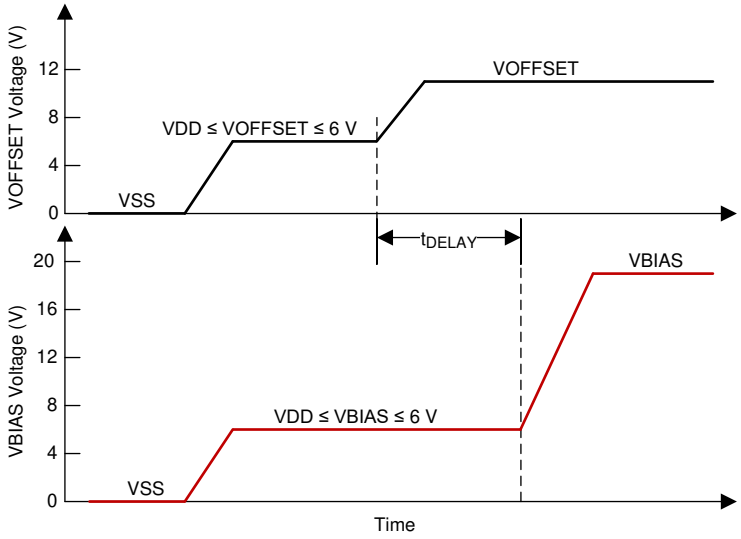
Table 9-1. Power-Up Sequence Delay Requirement

PARAMETER		MIN	MAX	UNIT
t_{DELAY}	Delay requirement from V_{OFFSET} power up to V_{BIAS} power up	2		ms
V_{OFFSET}	Supply voltage level during power–up sequence delay (see Figure 9-2)		6	V

Copyright © 2022 Texas Instruments Incorporated

Table 9-1. Power-Up Sequence Delay Requirement (continued)

PARAMETER		MIN	MAX	UNIT
V_{BIAS}	Supply voltage level during power–up sequence delay (see Figure 9-2)		6	V



A. Refer to Table 9-1 for V_{OFFSET} and V_{BIAS} supply voltage levels during power-up sequence delay.

Figure 9-2. Power-Up Sequence Delay Requirement

Copyright © 2022 Texas Instruments Incorporated

10 Layout

10.1 Layout Guidelines

There are no specific layout guidelines for the DMD as typically DMD is connected using a board to board connector to a flex cable. Flex cable provides the interface of data and control signals between the DLPC3478 controller and the 7212-313BK DMD. For detailed layout guidelines refer to the layout design files. Some layout guideline for the flex cable interface with DMD are:

- Match lengths for the LS_WDATA and LS_CLK signals.
- Minimize vias, layer changes, and turns for the HS bus signals. Refer Figure 10-1.
- Minimum of two 100-nF decoupling capacitor close to VBIAS. Capacitor C6 and C7 in Figure 10-1.
- Minimum of two 100-nF decoupling capacitor close to VRST. Capacitor C9 and C8 in Figure 10-1.
- Minimum of two 220-nF decoupling capacitor close to VOFS. Capacitor C5 and C4 in Figure 10-1.
- Minimum of four 100-nF decoupling capacitor close to VDDI and VDD. Capacitor C1, C2, C3 and C10 in Figure 10-1.

10.2 Layout Example

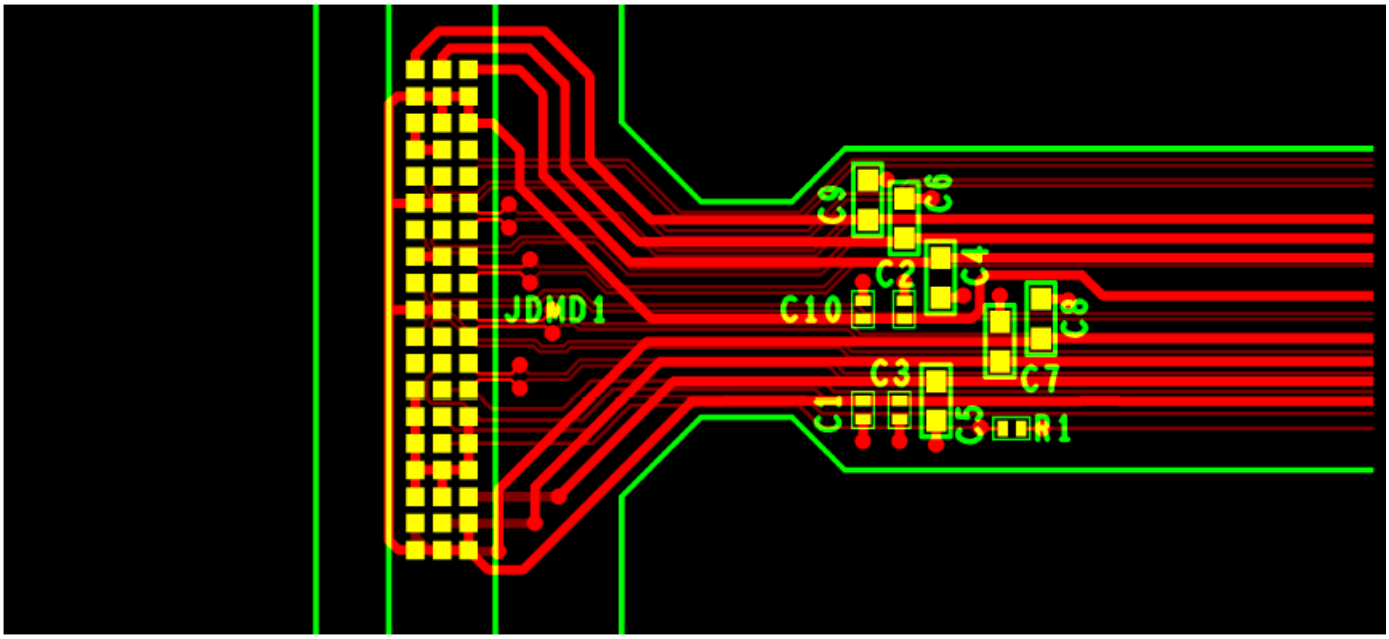


Figure 10-1. Power Supply Connections

11 Device and Documentation Support

11.1 Device Support

11.1.1 Third-Party Products Disclaimer

TI'S PUBLICATION OF INFORMATION REGARDING THIRD-PARTY PRODUCTS OR SERVICES DOES NOT CONSTITUTE AN ENDORSEMENT REGARDING THE SUITABILITY OF SUCH PRODUCTS OR SERVICES OR A WARRANTY, REPRESENTATION OR ENDORSEMENT OF SUCH PRODUCTS OR SERVICES, EITHER ALONE OR IN COMBINATION WITH ANY TI PRODUCT OR SERVICE.

11.1.2 Device Nomenclature

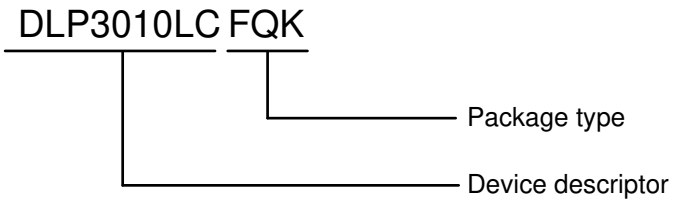


Figure 11-1. Part Number Description

11.1.3 Device Markings

The device marking includes the legible character string GHJJJJK DLP3010LCFQK. GHJJJJK is the lot trace code. DLP3010LCFQK is the orderable device number.

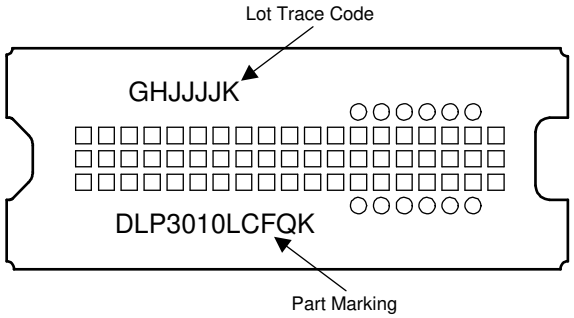


Figure 11-2. DMD Marking

11.2 Documentation Support

11.3 Receiving Notification of Documentation Updates

To receive notification of documentation updates, navigate to the device product folder on ti.com. Click on *Subscribe to updates* to register and receive a weekly digest of any product information that has changed. For change details, review the revision history included in any revised document.

11.4 Related Links

Table 11-1 lists quick access links. Categories include technical documents, support and community resources, tools and software, and quick access to sample or buy.

Table 11-1. Related Links

PARTS	PRODUCT FOLDER	SAMPLE & BUY	TECHNICAL DOCUMENTS	TOOLS & SOFTWARE	SUPPORT & COMMUNITY
DLPC3478	Click here	Click here	Click here	Click here	Click here
DLPA2000	Click here	Click here	Click here	Click here	Click here
DLPA2005	Click here	Click here	Click here	Click here	Click here
DLPA3000	Click here	Click here	Click here	Click here	Click here

Copyright © 2022 Texas Instruments Incorporated

Table 11-1. Related Links (continued)

PARTS	PRODUCT FOLDER	SAMPLE & BUY	TECHNICAL DOCUMENTS	TOOLS & SOFTWARE	SUPPORT & COMMUNITY
DLPA3005	Click here	Click here	Click here	Click here	Click here

11.5 Support Resources

TI E2E™ support forums are an engineer's go-to source for fast, verified answers and design help — straight from the experts. Search existing answers or ask your own question to get the quick design help you need.

Linked content is provided "AS IS" by the respective contributors. They do not constitute TI specifications and do not necessarily reflect TI's views; see TI's Terms of Use.

11.6 Trademarks

Pico™, IntelliBright™, and TI E2E™ are trademarks of Texas Instruments.
DLP® is a registered trademark of Texas Instruments.
All trademarks are the property of their respective owners.

11.7 Electrostatic Discharge Caution

This integrated circuit can be damaged by ESD. Texas Instruments recommends that all integrated circuits be handled with appropriate precautions. Failure to observe proper handling and installation procedures can cause damage.

ESD damage can range from subtle performance degradation to complete device failure. Precision integrated circuits may be more susceptible to damage because very small parametric changes could cause the device not to meet its published specifications.

11.8 Glossary

TI Glossary This glossary lists and explains terms, acronyms, and definitions.

12 Mechanical, Packaging, and Orderable Information

The following pages include mechanical, packaging, and orderable information. This information is the most current data available for the designated devices. This data is subject to change without notice and revision of this document. For browser-based versions of this data sheet, refer to the left-hand navigation.

Copyright © 2022 Texas Instruments Incorporated

PACKAGING INFORMATION

Orderable Device	Status (1)	Package Type	Package Drawing	Pins	Package Qty	Eco Plan (2)	Lead finish/ Ball material (6)	MSL Peak Temp (3)	Op Temp (°C)	Device Marking (4/5)	Samples
DLP3010LCFQK	ACTIVE	CLGA	FQK	57	120	RoHS & Green	NI/AU	N / A for Pkg Type	0 to 70		Samples

(1) The marketing status values are defined as follows:
ACTIVE: Product device recommended for new designs.
LIFEBUY: TI has announced that the device will be discontinued, and a lifetime-buy period is in effect.
NRND: Not recommended for new designs. Device is in production to support existing customers, but TI does not recommend using this part in a new design.
PREVIEW: Device has been announced but is not in production. Samples may or may not be available.
OBSOLETE: TI has discontinued the production of the device.

(2) **RoHS:** TI defines "RoHS" to mean semiconductor products that are compliant with the current EU RoHS requirements for all 10 RoHS substances, including the requirement that RoHS substance do not exceed 0.1% by weight in homogeneous materials. Where designed to be soldered at high temperatures, "RoHS" products are suitable for use in specified lead-free processes. TI may reference these types of products as "Pb-Free".
RoHS Exempt: TI defines "RoHS Exempt" to mean products that contain lead but are compliant with EU RoHS pursuant to a specific EU RoHS exemption.
Green: TI defines "Green" to mean the content of Chlorine (Cl) and Bromine (Br) based flame retardants meet JS709B low halogen requirements of <=1000ppm threshold. Antimony trioxide based flame retardants must also meet the <=1000ppm threshold requirement.

(3) MSL, Peak Temp. - The Moisture Sensitivity Level rating according to the JEDEC industry standard classifications, and peak solder temperature.

(4) There may be additional marking, which relates to the logo, the lot trace code information, or the environmental category on the device.

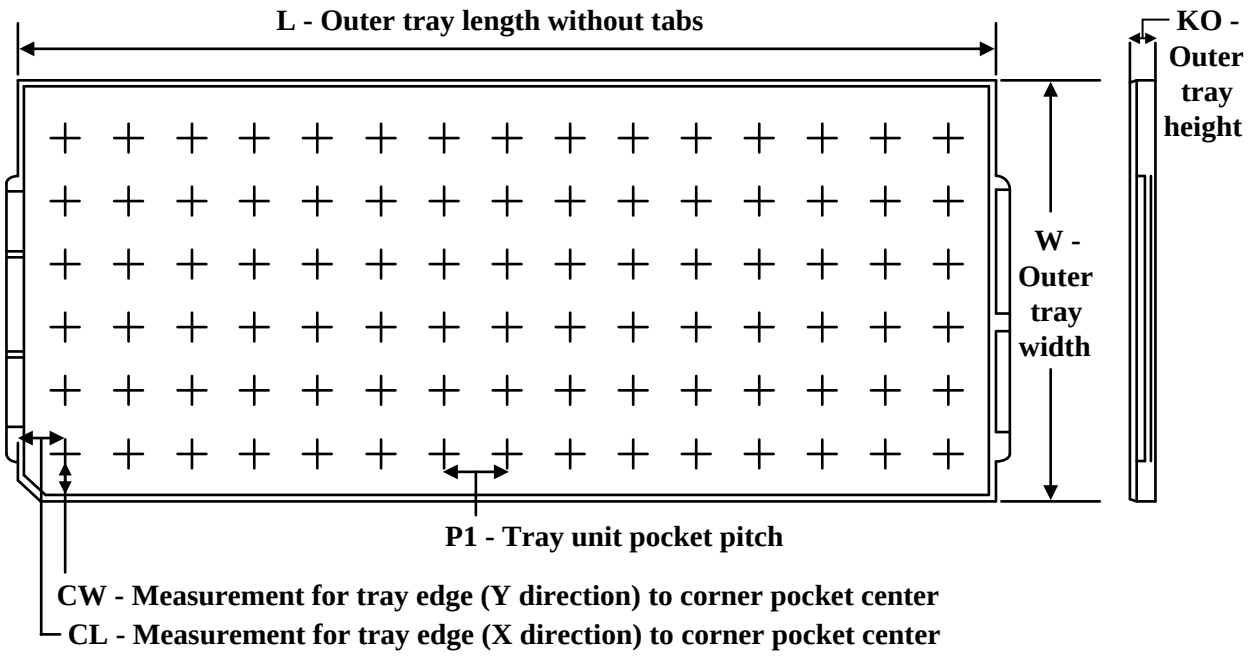
(5) Multiple Device Markings will be inside parentheses. Only one Device Marking contained in parentheses and separated by a "~" will appear on a device. If a line is indented then it is a continuation of the previous line and the two combined represent the entire Device Marking for that device.

(6) Lead finish/Ball material - Orderable Devices may have multiple material finish options. Finish options are separated by a vertical ruled line. Lead finish/Ball material values may wrap to two lines if the finish value exceeds the maximum column width.

Important Information and Disclaimer: The information provided on this page represents TI's knowledge and belief as of the date that it is provided. TI bases its knowledge and belief on information provided by third parties, and makes no representation or warranty as to the accuracy of such information. Efforts are underway to better integrate information from third parties. TI has taken and continues to take reasonable steps to provide representative and accurate information but may not have conducted destructive testing or chemical analysis on incoming materials and chemicals. TI and TI suppliers consider certain information to be proprietary, and thus CAS numbers and other limited information may not be available for release.

In no event shall TI's liability arising out of such information exceed the total purchase price of the TI part(s) at issue in this document sold by TI to Customer on an annual basis.

TRAY



Chamfer on Tray corner indicates Pin 1 orientation of packed units.

*All dimensions are nominal

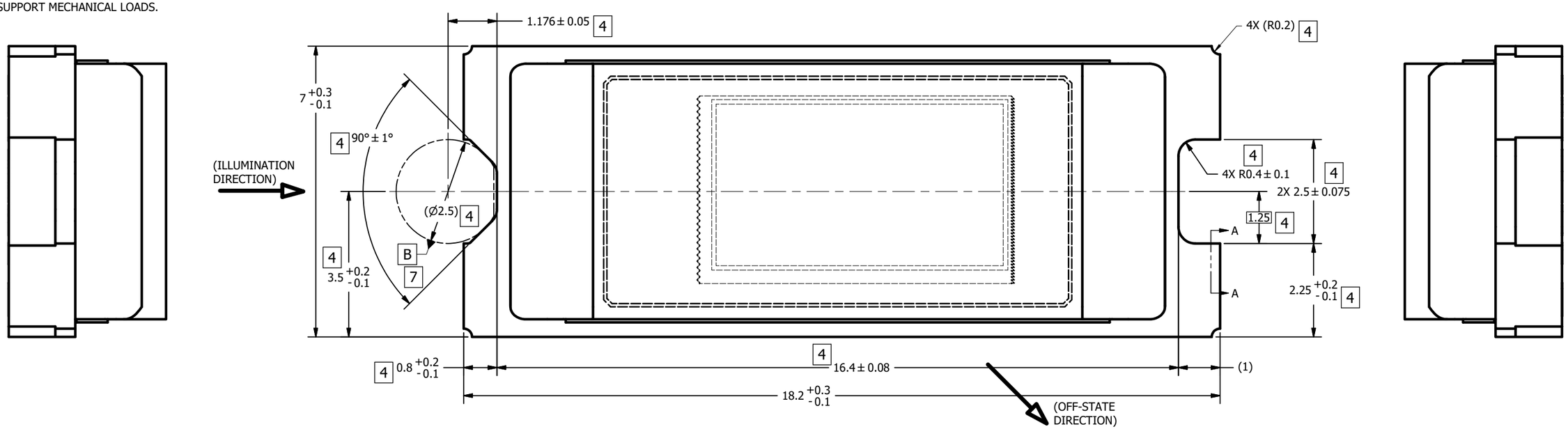
Device	Package Name	Package Type	Pins	SPQ	Unit array matrix	Max temperature (°C)	L (mm)	W (mm)	K0 (µm)	P1 (mm)	CL (mm)	CW (mm)
DLP3010LCFQK	FQK	CLGA	57	120	10 x 12	150	315	135.9	12190	23	31	16.2

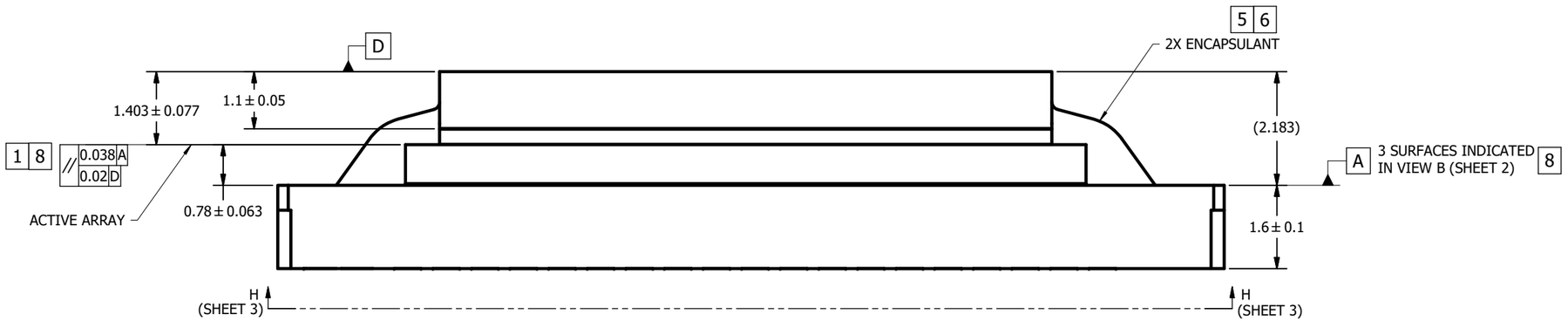
© COPYRIGHT 2013 TEXAS INSTRUMENTS
UN-PUBLISHED, ALL RIGHTS RESERVED.

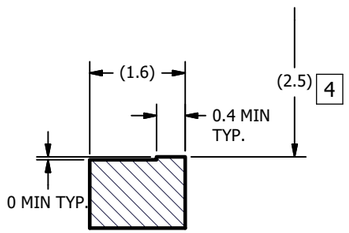
REVISIONS			
REV	DESCRIPTION	DATE	BY
A	ECO 2133835: INITIAL RELEASE	6/6/2013	BMH
B	ECO 2134093: CORRECT WINDOW THK TOL, ZONE B6	6/17/2013	BMH
C	ECO 2186947: ADD APERTURE SLOTS PICTORIALLY	4/8/2020	PPC

NOTES UNLESS OTHERWISE SPECIFIED:

1. DIE PARALLELISM TOLERANCE APPLIES TO DMD ACTIVE ARRAY ONLY.
2. ROTATION ANGLE OF DMD ACTIVE ARRAY IS A REFINEMENT OF THE LOCATION TOLERANCE AND HAS A MAXIMUM ALLOWED VALUE OF 0.6 DEGREES.
3. BOUNDARY MIRRORS SURROUNDING THE DMD ACTIVE ARRAY.
4. NOTCH DIMENSIONS ARE DEFINED BY UPPERMOST LAYERS OF CERAMIC, AS SHOWN IN SECTION A-A.
5. ENCAPSULANT TO BE CONTAINED WITHIN DIMENSIONS SHOWN IN VIEW C (SHEET 2). NO ENCAPSULANT IS ALLOWED ON TOP OF THE WINDOW.
6. ENCAPSULANT NOT TO EXCEED THE HEIGHT OF THE WINDOW.
7. DATUM B IS DEFINED BY A DIA. 2.5 PIN, WITH A FLAT ON THE SIDE FACING TOWARD THE CENTER OF THE ACTIVE ARRAY, AS SHOWN IN VIEW B (SHEET 2).
8. WHILE ONLY THE THREE DATUM A TARGET AREAS A1, A2, AND A3 ARE USED FOR MEASUREMENT, ALL 4 CORNERS SHOULD BE CONTACTED, INCLUDING E1, TO SUPPORT MECHANICAL LOADS.







SECTION A-A
NOTCH OFFSETS

	0314DA
NEXT ASSY	USED ON
APPLICATION	

THIRD ANGLE PROJECTION

UNLESS OTHERWISE SPECIFIED
- DIMENSIONS ARE IN MILLIMETERS
- TOLERANCES:
  - ANGLES ± 1°
  - 2 PLACE DECIMALS ± 0.25
  - 1 PLACE DECIMALS ± 0.50
- ~~DIMENSIONAL LIMITS APPLY BEFORE PROCESSES~~
- INTERPRET DIMENSIONS IN ACCORDANCE WITH ASME Y14.5M-1994
- ~~REMOVE ALL BURRS AND SHARP EDGES~~
- PARENTHETICAL INFORMATION FOR REFERENCE ONLY

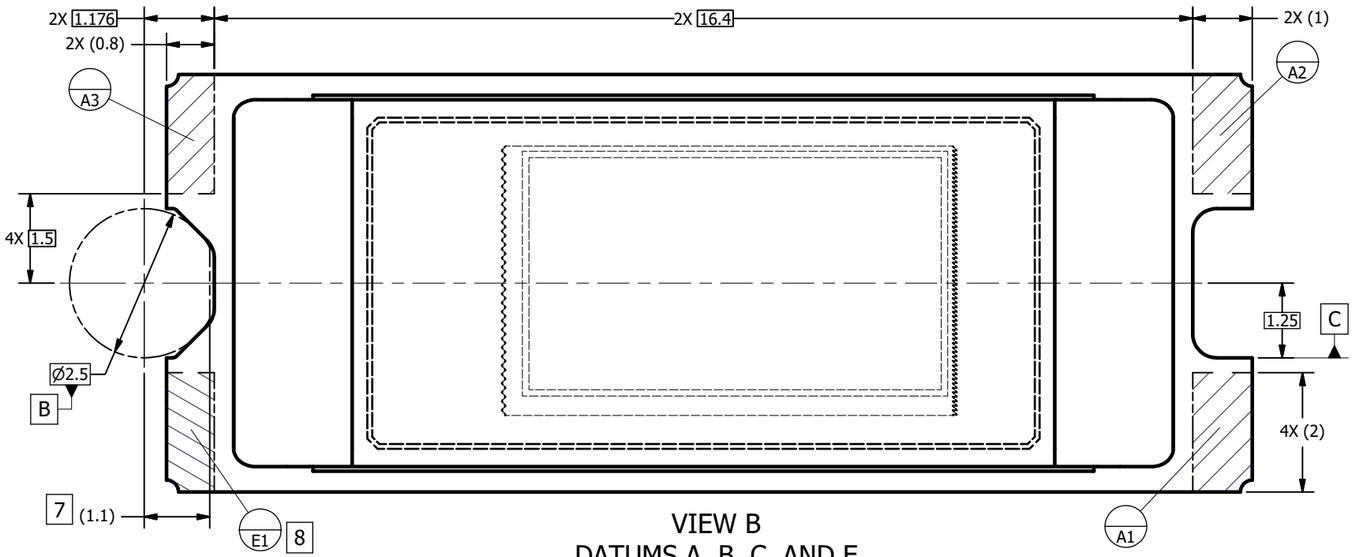
		DATE
DRAWN	B. HASKETT	6/6/2013
ENGINEER	B. HASKETT	6/6/2013
QA/CE	P. KONRAD	6/7/2013
CM	S. SUSI	6/6/2013
	S. CROFF	6/10/2013
APPROVED	R. LONG	6/6/2013

TEXAS INSTRUMENTS
Dallas Texas

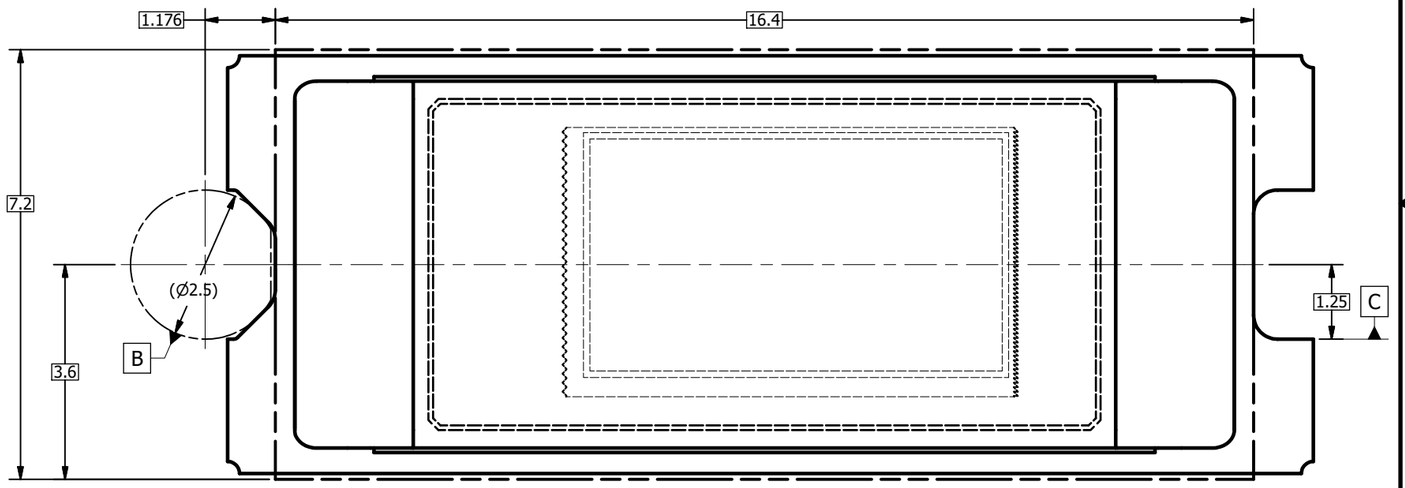
TITLE
ICD, MECHANICAL, DMD,
.3 720p SERIES 245
(FQK PACKAGE)

SIZE		DWG NO	REV
D		2512014	C
SCALE 20:1		SHEET 1 OF 3	

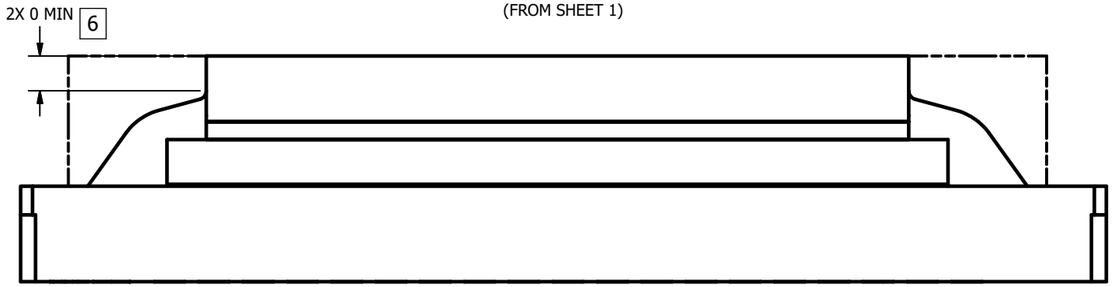
INV11-2006a



VIEW B
DATUMS A, B, C, AND E
(FROM SHEET 1)



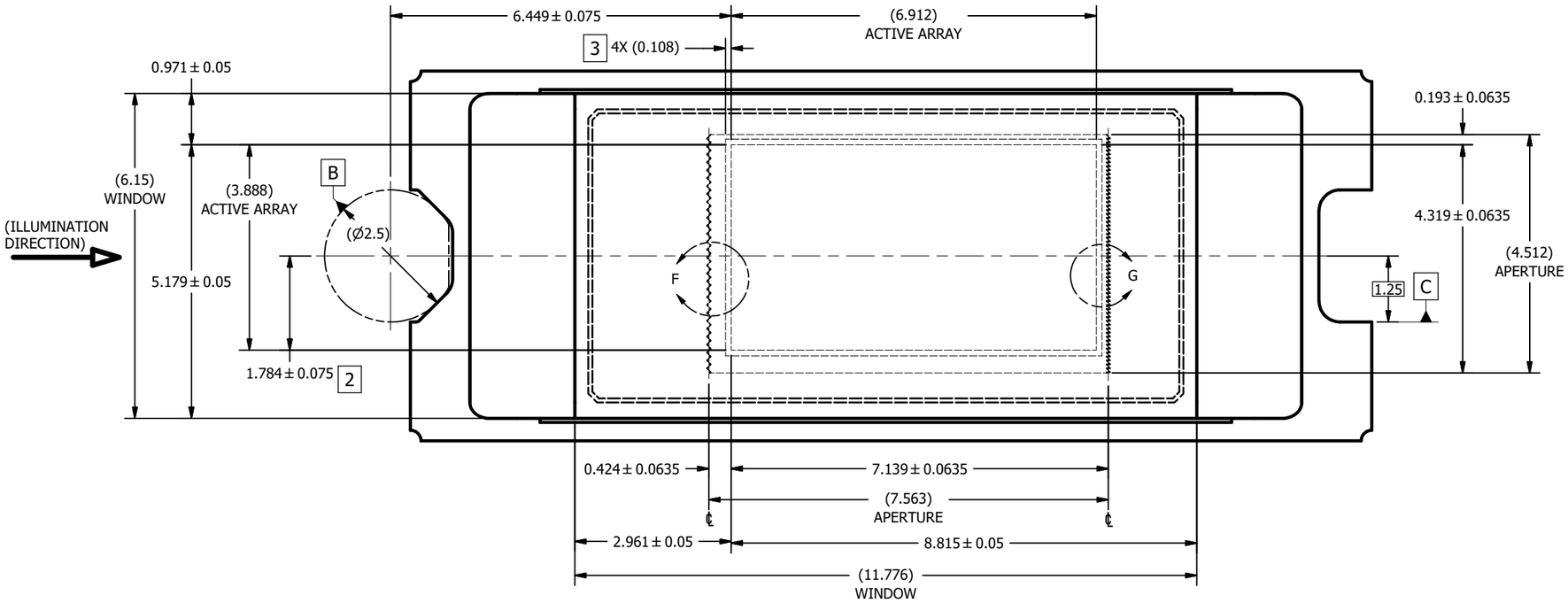
VIEW C 5
ENCAPSULANT MAXIMUM X/Y DIMENSIONS
(FROM SHEET 1)



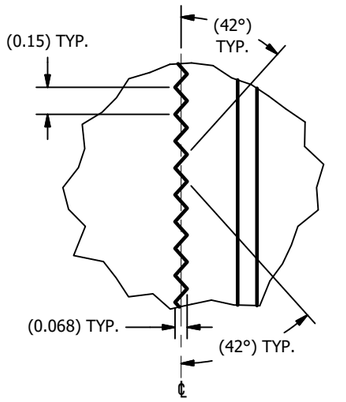
VIEW D
ENCAPSULANT MAXIMUM HEIGHT

Texas Instruments, Dallas Texas	DRAWN B. HASKETT	DATE 6/6/2013	SIZE D		DWG NO 2512014	REV C
			SCALE		SHEET 2 OF 3	

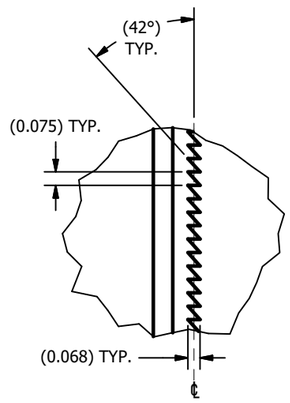
INV11-2006a



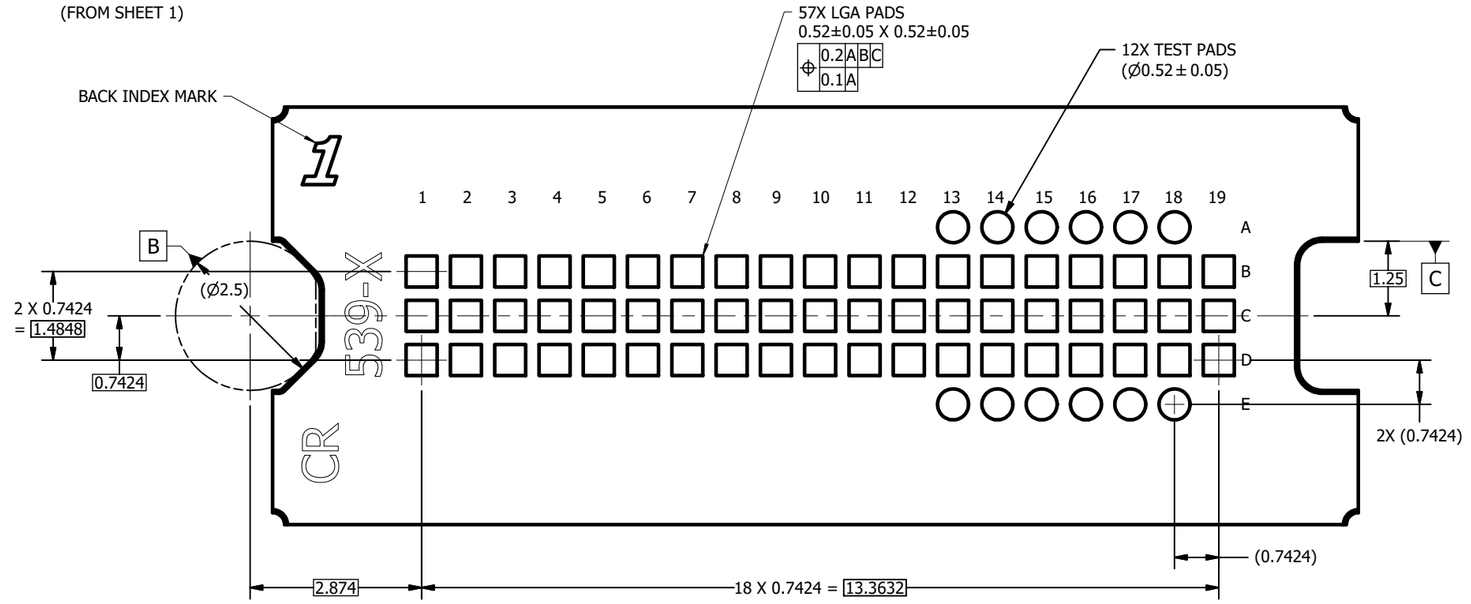
VIEW E
WINDOW AND ACTIVE ARRAY
(FROM SHEET 1)



DETAIL F
APERTURE LEFT EDGE
SCALE 60 : 1



DETAIL G
APERTURE RIGHT EDGE
SCALE 60 : 1



VIEW H-H
BACK SIDE METALLIZATION
(FROM SHEET 1)

Texas Instruments Dallas Texas	DRAWN B. HASKETT	DATE 6/6/2013	SIZE D	DWG NO 2512014	REV C
			SCALE	SHEET 3 OF 3	

INV11-2006a

IMPORTANT NOTICE AND DISCLAIMER

TI PROVIDES TECHNICAL AND RELIABILITY DATA (INCLUDING DATA SHEETS), DESIGN RESOURCES (INCLUDING REFERENCE DESIGNS), APPLICATION OR OTHER DESIGN ADVICE, WEB TOOLS, SAFETY INFORMATION, AND OTHER RESOURCES “AS IS” AND WITH ALL FAULTS, AND DISCLAIMS ALL WARRANTIES, EXPRESS AND IMPLIED, INCLUDING WITHOUT LIMITATION ANY IMPLIED WARRANTIES OF MERCHANTABILITY, FITNESS FOR A PARTICULAR PURPOSE OR NON-INFRINGEMENT OF THIRD PARTY INTELLECTUAL PROPERTY RIGHTS.

These resources are intended for skilled developers designing with TI products. You are solely responsible for (1) selecting the appropriate TI products for your application, (2) designing, validating and testing your application, and (3) ensuring your application meets applicable standards, and any other safety, security, regulatory or other requirements.

These resources are subject to change without notice. TI grants you permission to use these resources only for development of an application that uses the TI products described in the resource. Other reproduction and display of these resources is prohibited. No license is granted to any other TI intellectual property right or to any third party intellectual property right. TI disclaims responsibility for, and you will fully indemnify TI and its representatives against, any claims, damages, costs, losses, and liabilities arising out of your use of these resources.

TI’s products are provided subject to TI’s Terms of Sale or other applicable terms available either on ti.com or provided in conjunction with such TI products. TI’s provision of these resources does not expand or otherwise alter TI’s applicable warranties or warranty disclaimers for TI products.

TI objects to and rejects any additional or different terms you may have proposed.

Mailing Address: Texas Instruments, Post Office Box 655303, Dallas, Texas 75265
Copyright © 2022, Texas Instruments Incorporated